



# CERTIFICATE OF ACCREDITATION

## The ANSI National Accreditation Board

Hereby attests that

**Martin Calibration, Inc.**

**11965 12<sup>th</sup> Avenue South**

**Burnsville, MN 55337**

**Including satellite locations located in: Mundelein, IL and Eau Claire, WI**

Fulfills the requirements of

**ISO/IEC 17025:2017**

and national standard

**ANSI/NCSL Z540-1-1994 (R2002)**

In the fields of

**CALIBRATION and DIMENSIONAL MEASUREMENT**

This certificate is valid only when accompanied by a current scope of accreditation document.

The current scope of accreditation can be verified at [www.anab.org](http://www.anab.org).

Jason Stine, Vice President

Expiry Date: 06 July 2027

Certificate Number: ACT-1265



This laboratory is accredited in accordance with the recognized International Standard ISO/IEC 17025:2017.  
This accreditation demonstrates technical competence for a defined scope and the operation of a laboratory  
quality management system (refer to joint ISO-ILAC-IAF Communiqué dated April 2017).

**SCOPE OF ACCREDITATION TO ISO/IEC 17025:2017**

**AND**

**ANSI/NCSL Z540-1-1994 (R2002)**

**Martin Calibration, Inc.**

11965 12<sup>th</sup> Avenue South  
Burnsville, MN 55337

Corey Garbers  
952-882-1528

**CALIBRATION AND DIMENSIONAL MEASUREMENT**

ISO/IEC 17025 Accreditation Granted: **06 July 2025**

Certificate Number: **ACT-1265**

Certificate Expiry Date: **06 July 2027**

**Satellite locations in:**

Mundelein, IL

Eau Claire, WI

## Services performed at Main Site laboratory

### Martin Calibration, Inc.

11965 12<sup>th</sup> Avenue South  
Burnsville, MN 55337  
Corey Garbers  
952-882-1528

### CALIBRATION

#### Acoustics and Vibration

Burnsville, MN

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Sound Level			
Fixed Points	(94, 104, 114) dB	0.2 dB	
Linearity	(50 to 143) dB	0.13 dB	
Frequency	31 Hz to 16 kHz	1 % of reading	Comparison to Bruel & Kjaer Sound Pressure Calibrator
Distortion	(25 to 123) dB 31 Hz to 16 kHz	0.14 dB	
Accelerometers	(5 to 9) Hz (10 to 99) Hz 100 Hz (101 to 920) Hz 921 Hz to 5 kHz (5 to 8) kHz (8 to 10) kHz (10 to 15) kHz	2.6 % of reading 1.6 % of reading 0.75 % of reading 1.3 % of reading 2.2 % of reading 3.8 % of reading 4.8 % of reading 8.6 % of reading	Comparison to PCB Shaker Table with PCB Reference Accelerometer

#### Chemical Quantities

Burnsville, MN

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Conductivity Meters <sup>1</sup>	(0.86 to 10) $\mu$ S/cm (10 to 100) $\mu$ S/cm (100 to 1 500) $\mu$ S/cm 12 800 $\mu$ S/cm	0.42 $\mu$ S/cm 0.89 $\mu$ S/cm 0.42 % of reading 0.42 % of reading	Comparison to Conductivity Standards

## Chemical Quantities

Burnsville, MN

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Refractometers	0 Brix 10 Brix 40 Brix 70 Brix	0.000 6 Brix 0.018 Brix 0.019 Brix 0.03 Brix	Comparison to Calibration Solutions
pH Meters <sup>1</sup>	4 pH 7 pH 10 pH	0.016 pH 0.016 pH 0.016 pH	Comparison to Buffer Solutions

## Electrical – DC/Low Frequency

Burnsville, MN

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
DC Voltage – Source <sup>1</sup> (Fixed Artifact)	10 V	0.5 $\mu$ V/V	Comparison to Fluke 732B Voltage Standards with Fluke Maps
DC Voltage – Source <sup>1</sup>	(0 to 220) mV (0.22 to 2.2) V (2.2 to 11) V (11 to 22) V (22 to 220) V (220 to 1 100) V	7.5 $\mu$ V/V + 0.4 $\mu$ V 5 $\mu$ V/V + 0.7 $\mu$ V 3.5 $\mu$ V/V + 2.5 $\mu$ V 3.5 $\mu$ V/V + 4 $\mu$ V 5 $\mu$ V/V + 40 $\mu$ V 6.5 $\mu$ V/V + 0.4 mV	Fluke 5730A Multiproduct Calibrator; Direct Measure
DC Voltage – Measure <sup>1</sup>	0V Up to 1 mV (1 to 10) mV (10 to 100) mV (100 mV to 1) V (1 to 10) V (10 to 100) V (100 to 1 100) V	20 nV 100 nV 22 $\mu$ V/V + 25 nV 5.3 $\mu$ V/V 0.5 $\mu$ V/V 0.31 $\mu$ V/V 0.35 $\mu$ V/V 1 $\mu$ V/V	Comparison to Nano Voltmeter Fluke 732B Voltage Standard with MI Potentiometer/Divider
DC High Voltage – Measure <sup>1</sup>	(1.1 to 10) kV (10 to 30) kV (30 to 50) kV (50 to 70) kV (70 to 100) kV	0.05 % of reading 0.055 % of reading 0.079 % of reading 0.12 % of reading 0.83 % of reading	Comparison to Hipotronics KVM100-A High Voltage Meter
DC Current – Source & Measure <sup>1</sup>	0 A (0 to 200) pA (0.2 to 20) nA (20 to 100) nA	76 fA 1.9 % of reading + 10 fA 0.29 % of reading + 1 pA 8 $\mu$ A/A + 1.3 pA	Comparison to Electrometer

**Electrical – DC/Low Frequency**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
DC Current – Source & Measure <sup>1</sup>	(0.1 to 1) $\mu$ A (1 to 10) $\mu$ A (10 to 100) $\mu$ A (0.1 to 1) mA (1 to 10) mA (10 to 100) mA (0.1 to 1) A	30 $\mu$ A/A 6.8 $\mu$ A/A 6.2 $\mu$ A/A 4.1 $\mu$ A/A 4.2 $\mu$ A/A 3.9 $\mu$ A/A 17 $\mu$ A/A	Comparison to Standard Resistors and DMM, Multifunction Calibrator
DC Current – Measure <sup>1</sup>	(1 to 20) A (20 to 120) A	26 $\mu$ A/A 80 $\mu$ A/A + 4 mA	Comparison to Fluke 52120A Amplifier with Current Shunts
DC Current – Source <sup>1</sup>	(0.2 to 220) $\mu$ A (0.22 to 2.2) mA (2.2 to 22) mA (22 to 220) mA (0.22 to 2.2) A	40 $\mu$ A/A + 6 nA 35 $\mu$ A/A + 7 nA 35 $\mu$ A/A + 40 nA 45 $\mu$ A/A + 0.7 $\mu$ A 80 $\mu$ A/A + 12 $\mu$ A	Fluke 5730A Multiproduct Calibrator; Direct Measure
DC Current – Source <sup>1</sup>	Up to 2 A (2.2 to 11) A (2 to 20) A	0.036 % of reading + 0.48 mA 0.012 % of reading + 0.16 mA 0.012 % of reading + 1.6 mA	Fluke 5730A Multiproduct Calibrator, Fluke 5725A Amplifier; Direct Measure
DC Current – Source <sup>1</sup>	(20 to 120) A	0.012 % of reading + 9.6 mA	Fluke 5730A Multiproduct Calibrator, Fluke 52120A Current Amplifier; Direct Measure
DC Current – Source <sup>1</sup>	(100 to 150) A (150 to 1 025) A	5 mA/A + 20 mA 5.1 mA/A + 0.9 A	Comparison to Fluke 5520A Multi Product Calibrator with 50-turn Coil
DC Power – Source	10.9 $\mu$ W to 10.9 mW 10.9 mW to 3.06 kW (3.06 to 20.9) kW	0.18 mW/W 0.17 mW/W 0.54 mW/W	Comparison to Fluke 5520A Multi Product Calibrator
AC Power – Source (45 to 65) Hz	109 $\mu$ W to 1.09 mW (1.09 to 297) $\mu$ W 297 $\mu$ W to 2.97 mW 2.97 mW to 337 W 337 W to 2.24 kW (2.24 to 20.9) kW	1.1 mW/W 930 $\mu$ W/W 780 $\mu$ W/W 620 $\mu$ W/W 700 $\mu$ W/W 780 $\mu$ W/W	Comparison to Fluke 5520A Multi Product Calibrator

**Electrical – DC/Low Frequency**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Voltage – Source <sup>1</sup>	Up to 2.2 mV		Fluke 5730A Multiproduct Calibrator; Direct Measure
	(10 to 20) Hz	0.024 % of reading + 4 $\mu$ V	
	(20 to 40) Hz	0.009 % of reading + 4 $\mu$ V	
	40 Hz to 20 kHz	0.008 % of reading + 4 $\mu$ V	
	(20 to 50) kHz	0.02 % of reading + 4 $\mu$ V	
	(50 to 100) kHz	0.05 % of reading + 5 $\mu$ V	
	(100 to 300) kHz	0.11 % of reading + 10 $\mu$ V	
	(300 to 500) kHz	0.14 % of reading + 20 $\mu$ V	
	500 kHz to 1 MHz	0.27 % of reading + 20 $\mu$ V	
	(2.2 to 22) mV		
	(10 to 20) Hz	0.024 % of reading + 4 $\mu$ V	
	(20 to 40) Hz	0.009 % of reading + 4 $\mu$ V	
	40 Hz to 20 kHz	0.008 % of reading + 4 $\mu$ V	
	(20 to 50) kHz	0.02 % of reading + 4 $\mu$ V	
	(50 to 100) kHz	0.05 % of reading + 5 $\mu$ V	
	(100 to 300) kHz	0.11 % of reading + 10 $\mu$ V	
	(300 to 500) kHz	0.14 % of reading + 20 $\mu$ V	
	500 kHz to 1 MHz	0.27 % of reading + 20 $\mu$ V	
	(22 to 220) mV		
	(10 to 20) Hz	0.024 % of reading + 12 $\mu$ V	
	(20 to 40) Hz	0.009 % of reading + 7 $\mu$ V	
	40 Hz to 20 kHz	0.005 7 % of reading + 7 $\mu$ V	
	(20 to 50) kHz	0.012 % of reading + 7 $\mu$ V	
	(50 to 100) kHz	0.031 % of reading + 17 $\mu$ V	
	(100 to 300) kHz	0.066 % of reading + 20 $\mu$ V	
	(300 to 500) kHz	0.14 % of reading + 25 $\mu$ V	
	500 kHz to 1 MHz	0.27 % of reading + 45 $\mu$ V	



**Electrical – DC/Low Frequency**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Voltage – Source <sup>1</sup>	(0.22 to 2.2) V		Fluke 5730A Multiproduct Calibrator; Direct Measure
	(10 to 20) Hz	0.024 % of reading + 40 $\mu$ V	
	(20 to 40) Hz	0.009 % of reading + 15 $\mu$ V	
	40 Hz to 20 kHz	0.004 2 % of reading + 8 $\mu$ V	
	(20 to 50) kHz	0.006 7 % of reading + 10 $\mu$ V	
	(50 to 100) kHz	0.008 5 % of reading + 30 $\mu$ V	
	(100 to 300) kHz	0.034 % of reading + 80 $\mu$ V	
	(300 to 500) kHz	0.1 % of reading + 0.2 mV	
	500 kHz to 1 MHz	0.17 % of reading + 0.3 mV	
	(2.2 to 22) V		
	(10 to 20) Hz	0.024 % of reading + 0.4 mV	
	(20 to 40) Hz	0.009 % of reading + 0.15 mV	
	40 Hz to 20 kHz	0.004 2 % of reading + 50 $\mu$ V	
	(20 to 50) kHz	0.006 7 % of reading + 0.1 mV	
	(50 to 100) kHz	0.008 3 % of reading + 0.2 mV	
	(100 to 300) kHz	0.034 % of reading + 0.6 mV	
	(300 to 500) kHz	0.1 % of reading + 2 mV	
	500 kHz to 1 MHz	0.17 % of reading + 3.2 mV	
	(22 to 220) V		
	(10 to 20) Hz	0.024 % of reading + 4 mV	
	(20 to 40) Hz	0.009 % of reading + 1.5 mV	
AC Voltage – Source <sup>1</sup>	40 Hz to 20 kHz	0.005 2 % of reading + 0.6 mV	Fluke 5730A Multiproduct Calibrator, Fluke 5725A Amplifier; Direct Measure
	(20 to 50) kHz	0.008 % of reading + 1 mV	
	(50 to 100) kHz	0.015 % of reading + 2.5 mV	
	(100 to 300) kHz	0.09 % of reading + 16 mV	
	(300 to 500) kHz	0.44 % of reading + 40 mV	
	500 kHz to 1 MHz	0.8 % of reading + 80 mV	
	(220 to 250) V		
	(15 to 50) Hz	0.03 % of reading + 16 mV	
	(250 to 1 100) V		
	50 Hz to 1 kHz	0.007 % of reading + 3.5 mV	
AC Voltage – Source <sup>1</sup>	(220 to 750) V		Fluke 5730A Multiproduct Calibrator, Fluke 5725A Amplifier; Direct Measure
	(30 to 50) kHz	0.06 % of reading + 11 mV	
	(50 to 100) kHz	0.06 % of reading + 11 mV	
	(220 to 1 100) V		
	40 Hz to 1 kHz	0.009 % of reading + 4 mV	
	(1 to 20) kHz	0.017 % of reading + 6 mV	
	(20 to 30) kHz	0.23 % of reading + 45 mV	

**Electrical – DC/Low Frequency**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Voltage – Source & Measure <sup>1</sup>	Up to 2.2 mV		Comparison to Fluke 5790A AC Standard with Fluke 5720A Multi Product Calibrator
	(10 to 20) Hz	1.1 mV/V + 1.3 $\mu$ V	
	(20 to 40) Hz	490 $\mu$ V/V + 1.3 $\mu$ V	
	(0.04 to 20) kHz	280 $\mu$ V/V + 1.3 $\mu$ V	
	(20 to 50) kHz	540 $\mu$ V/V + 2 $\mu$ V	
	(50 to 100) kHz	800 $\mu$ V/V + 2.5 $\mu$ V	
	(100 to 300) kHz	1.5 mV/V + 4 $\mu$ V	
	(300 to 500) kHz	1.6 mV/V + 8 $\mu$ V	
	(0.5 to 1) MHz	2.3 mV/V + 8 $\mu$ V	
	(2.2 to 7) mV		
	(10 to 20) Hz	570 $\mu$ V/V + 1.3 $\mu$ V	
	(20 to 40) Hz	250 $\mu$ V/V + 1.3 $\mu$ V	
	(0.04 to 20) kHz	140 $\mu$ V/V + 1.3 $\mu$ V	
	(20 to 50) kHz	270 $\mu$ V/V + 2 $\mu$ V	
	(50 to 100) kHz	400 $\mu$ V/V + 2.5 $\mu$ V	
	(100 to 300) kHz	800 $\mu$ V/V + 4 $\mu$ V	
	(300 to 500) kHz	870 $\mu$ V/V + 8 $\mu$ V	
	(0.5 to 1) MHz	1.5 mV/V + 8 $\mu$ V	
	(7 to 22) mV		
	(10 to 20) Hz	190 $\mu$ V/V + 1.3 $\mu$ V	
	(20 to 40) Hz	130 $\mu$ V/V + 1.3 $\mu$ V	
	(0.04 to 20) kHz	73 $\mu$ V/V + 1.3 $\mu$ V	
	(20 to 50) kHz	140 $\mu$ V/V + 2 $\mu$ V	
	(50 to 100) kHz	210 $\mu$ V/V + 2.5 $\mu$ V	
	(100 to 300) kHz	540 $\mu$ V/V + 4 $\mu$ V	
	(300 to 500) kHz	590 $\mu$ V/V + 8 $\mu$ V	
	(0.5 to 1) MHz	1.1 mV/V + 8 $\mu$ V	
	(22 to 70) mV		
	(10 to 20) Hz	160 $\mu$ V/V + 1.5 $\mu$ V	
	(20 to 40) Hz	80 $\mu$ V/V + 1.5 $\mu$ V	
	(0.04 to 20) kHz	43 $\mu$ V/V + 1.5 $\mu$ V	
	(20 to 50) kHz	87 $\mu$ V/V + 2 $\mu$ V	
	(50 to 100) kHz	170 $\mu$ V/V + 2.5 $\mu$ V	
	(100 to 300) kHz	340 $\mu$ V/V + 4 $\mu$ V	
	(300 to 500) kHz	450 $\mu$ V/V + 8 $\mu$ V	
	(0.5 to 1) MHz	730 $\mu$ V/V + 8 $\mu$ V	



**Electrical – DC/Low Frequency**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Voltage – Source & Measure <sup>1</sup>	(70 to 220) mV		Comparison to Fluke 5790A AC Standard with Fluke 5720A Multi Product Calibrator
	(10 to 20) Hz	140 $\mu\text{V/V} + 1.5 \mu\text{V}$	
	(20 to 40) Hz	57 $\mu\text{V/V} + 1.5 \mu\text{V}$	
	(0.04 to 20) kHz	25 $\mu\text{V/V} + 1.5 \mu\text{V}$	
	(20 to 50) kHz	46 $\mu\text{V/V} + 2 \mu\text{V}$	
	(50 to 100) kHz	110 $\mu\text{V/V} + 2.5 \mu\text{V}$	
	(100 to 300) kHz	170 $\mu\text{V/V} + 4 \mu\text{V}$	
	(300 to 500) kHz	250 $\mu\text{V/V} + 8 \mu\text{V}$	
	(0.5 to 1) MHz	670 $\mu\text{V/V} + 8 \mu\text{V}$	
	(220 to 700) mV		
	(10 to 20) Hz	140 $\mu\text{V/V} + 1.5 \mu\text{V}$	
	(20 to 40) Hz	51 $\mu\text{V/V} + 1.5 \mu\text{V}$	
	(0.04 to 20) kHz	22 $\mu\text{V/V} + 1.5 \mu\text{V}$	
	(20 to 50) kHz	34 $\mu\text{V/V} + 2 \mu\text{V}$	
	(50 to 100) kHz	53 $\mu\text{V/V} + 2.5 \mu\text{V}$	
	(100 to 300) kHz	120 $\mu\text{V/V} + 4 \mu\text{V}$	
	(300 to 500) kHz	200 $\mu\text{V/V} + 8 \mu\text{V}$	
	(0.5 to 1) MHz	640 $\mu\text{V/V} + 8 \mu\text{V}$	
	(0.7 to 2.2) V		
	(10 to 20) Hz	130 $\mu\text{V/V}$	
	(20 to 40) Hz	44 $\mu\text{V/V}$	
	(0.04 to 20) kHz	16 $\mu\text{V/V}$	
	(20 to 50) kHz	31 $\mu\text{V/V}$	
	(50 to 100) kHz	47 $\mu\text{V/V}$	
	(100 to 300) kHz	110 $\mu\text{V/V}$	
	(300 to 500) kHz	170 $\mu\text{V/V}$	
	(0.5 to 1) MHz	600 $\mu\text{V/V}$	
	(2.2 to 7) V		
	(10 to 20) Hz	130 $\mu\text{V/V}$	
	(20 to 40) Hz	45 $\mu\text{V/V}$	
	(0.04 to 20) kHz	16 $\mu\text{V/V}$	
	(20 to 50) kHz	32 $\mu\text{V/V}$	
	(50 to 100) kHz	54 $\mu\text{V/V}$	
	(100 to 300) kHz	130 $\mu\text{V/V}$	
	(300 to 500) kHz	270 $\mu\text{V/V}$	
	(0.5 to 1) MHz	800 $\mu\text{V/V}$	

**Electrical – DC/Low Frequency**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Voltage – Source & Measure <sup>1</sup>	(7 to 22) V		Comparison to Fluke 5790A AC Standard with Fluke 5720A Multi Product Calibrator
	(10 to 20) Hz	130 $\mu$ V/V	
	(20 to 40) Hz	45 $\mu$ V/V	
	(0.04 to 20) kHz	18 $\mu$ V/V	
	(20 to 50) kHz	32 $\mu$ V/V	
	(50 to 100) kHz	54 $\mu$ V/V	
	(100 to 300) kHz	130 $\mu$ V/V	
	(300 to 500) kHz	270 $\mu$ V/V	
	(0.5 to 1) MHz	800 $\mu$ V/V	
	(22 to 70) V		
	(10 to 20) Hz	130 $\mu$ V/V	
	(20 to 40) Hz	45 $\mu$ V/V	
	(0.04 to 20) kHz	21 $\mu$ V/V	
	(20 to 50) kHz	38 $\mu$ V/V	
	(50 to 100) kHz	63 $\mu$ V/V	
	(100 to 300) kHz	130 $\mu$ V/V	
	(300 to 500) kHz	270 $\mu$ V/V	
	(0.5 to 1) MHz	800 $\mu$ V/V	
	(70 to 220) V		
	(10 to 20) Hz	130 $\mu$ V/V	
	(20 to 40) Hz	45 $\mu$ V/V	
	(0.04 to 20) kHz	21 $\mu$ V/V	
	(20 to 50) kHz	46 $\mu$ V/V	
	(50 to 100) kHz	65 $\mu$ V/V	
	(100 to 300) kHz	140 $\mu$ V/V	
	(300 to 500) kHz	330 $\mu$ V/V	
	(220 to 700) V		
	(10 to 20) Hz	130 $\mu$ V/V	
	(20 to 40) Hz	66 $\mu$ V/V	
	(0.04 to 20) kHz	27 $\mu$ V/V	
	(20 to 50) kHz	87 $\mu$ V/V	
	(50 to 100) kHz	330 $\mu$ V/V	

**Electrical – DC/Low Frequency**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Voltage – Source & Measure Flatness relative to 1 kHz	Up to 2.2 mV		Comparison to Fluke 5790A AC Standard with Fluke 5720A Multi Product Calibrator (Wideband)
	(10 to 30) Hz	0.1 % of reading + 1.3 $\mu$ V	
	(30 to 120) Hz	0.05 % of reading + 1.3 $\mu$ V	
	(0.12 to 1.2) kHz	0.05 % of reading + 1.3 $\mu$ V	
	(1.2 to 120) kHz	0.05 % of reading + 2 $\mu$ V	
	(120 to 500) kHz	0.07 % of reading + 1 $\mu$ V	
	(0.5 to 1.2) MHz	0.07 % of reading + 1 $\mu$ V	
	(1.2 to 2) MHz	0.07 % of reading + 1 $\mu$ V	
	(2 to 10) MHz	0.17 % of reading + 1 $\mu$ V	
	(10 to 20) MHz	0.32 % of reading + 1 $\mu$ V	
	(20 to 30) MHz	0.7 % of reading + 2 $\mu$ V	
	(2.2 to 7) mV		
	(10 to 30) Hz	0.1 % of reading	
	(30 to 120) Hz	0.05 % of reading	
	(0.12 to 1.2) kHz	0.05 % of reading	
	(1.2 to 120) kHz	0.05 % of reading	
	(120 to 500) kHz	0.07 % of reading + 1 $\mu$ V	
	(0.5 to 1.2) MHz	0.07 % of reading + 1 $\mu$ V	
	(1.2 to 2) MHz	0.07 % of reading + 1 $\mu$ V	
	(2 to 10) MHz	0.1 % of reading + 1 $\mu$ V	
	(10 to 20) MHz	0.17 % of reading + 1 $\mu$ V	
	(20 to 30) MHz	0.37 % of reading + 1 $\mu$ V	
	(7 to 22) mV		
	(10 to 30) Hz	0.1 % of reading	
	(30 to 120) Hz	0.05 % of reading	
	(0.12 to 1.2) kHz	0.05 % of reading	
	(1.2 to 120) kHz	0.05 % of reading	
	(120 to 500) kHz	0.07 % of reading	
	(0.5 to 1.2) MHz	0.07 % of reading	
	(1.2 to 2) MHz	0.07 % of reading	
	(2 to 10) MHz	0.1 % of reading	
	(10 to 20) MHz	0.17 % of reading	
	(20 to 30) MHz	0.37 % of reading	

**Electrical – DC/Low Frequency**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Voltage – Source & Measure Flatness relative to 1 kHz	(22 to 70) mV		Comparison to Fluke 5790A AC Standard with Fluke 5720A Multi Product Calibrator (Wideband)
	(10 to 30) Hz	0.1 % of reading	
	(30 to 120) Hz	0.05 % of reading %	
	(0.12 to 1.2) kHz	0.05 % of reading	
	(1.2 to 120) kHz	0.05 % of reading	
	(120 to 500) kHz	0.05 % of reading	
	(0.5 to 1.2) MHz	0.05 % of reading	
	(1.2 to 2) MHz	0.05 % of reading	
	(2 to 10) MHz	0.1 % of reading	
	(10 to 20) MHz	0.15 % of reading	
	(20 to 30) MHz	0.35 % of reading	
	(70 to 220) mV		
	(10 to 30) Hz	0.1 % of reading	
	(30 to 120) Hz	0.04 % of reading	
	(0.12 to 1.2) kHz	0.04 % of reading	
	(1.2 to 120) kHz	0.04 % of reading	
	(120 to 500) kHz	0.04 % of reading	
	(0.5 to 1.2) MHz	0.05 % of reading	
	(1.2 to 2) MHz	0.05 % of reading	
	(2 to 10) MHz	0.1 % of reading	
	(10 to 20) MHz	0.15 % of reading	
	(20 to 30) MHz	0.35 % of reading	
	(220 to 700) mV		
	(10 to 30) Hz	0.1 % of reading	
	(30 to 120) Hz	0.03 % of reading	
	(0.12 to 1.2) kHz	0.03 % of reading	
	(1.2 to 120) kHz	0.03 % of reading	
	(120 to 500) kHz	0.03 % of reading	
	(0.5 to 1.2) MHz	0.05 % of reading	
	(1.2 to 2) MHz	0.05 % of reading	
	(2 to 10) MHz	0.1 % of reading	
	(10 to 20) MHz	0.15 % of reading	
	(20 to 30) MHz	0.35 % of reading	

**Electrical – DC/Low Frequency**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Voltage – Source & Measure Flatness relative to 1 kHz	(0.7 to 2.2) V (10 to 30) Hz (30 to 120) Hz (0.12 to 1.2) kHz (1.2 to 120) kHz (120 to 500) kHz (0.5 to 1.2) MHz (1.2 to 2) MHz (2 to 10) MHz (10 to 20) MHz (20 to 30) MHz	0.1 % of reading 0.03 % of reading 0.03 % of reading 0.03 % of reading 0.03 % of reading 0.05 % of reading 0.05 % of reading 0.1 % of reading 0.15 % of reading 0.35 % of reading	Comparison to Fluke 5790A AC Standard with Fluke 5720A Multi Product Calibrator (Wideband)
	(2.2 to 7) V (10 to 30) Hz (30 to 120) Hz (0.12 to 1.2) kHz (1.2 to 120) kHz (120 to 500) kHz (0.5 to 1.2) MHz (1.2 to 2) MHz (2 to 10) MHz (10 to 20) MHz (20 to 30) MHz	0.1 % of reading 0.03 % of reading 0.03 % of reading 0.03 % of reading 0.03 % of reading 0.05 % of reading 0.05 % of reading 0.1 % of reading 0.15 % of reading 0.35 % of reading	
AC Current – Source <sup>1</sup>	Up to 220 $\mu$ A (10 to 20) Hz (20 to 40) Hz 40 Hz to 1 kHz (1 to 5) kHz (5 to 10) kHz (0.22 to 2.2) mA (10 to 20) Hz (20 to 40) Hz 40 Hz to 1 kHz (1 to 5) kHz (5 to 10) kHz (2.2 to 22) mA (10 to 20) Hz (20 to 40) Hz 40 Hz to 1 kHz (1 to 5) kHz (5 to 10) kHz	0.025 % of reading + 16 nA 0.016 % of reading + 10 nA 0.011 % of reading + 8 nA 0.028 % of reading + 12 nA 0.11 % of reading + 65 nA 0.25 % of reading + 40 nA 0.016 % of reading + 35 nA 0.011 % of reading + 35 nA 0.02 % of reading + 0.11 $\mu$ A 0.11 % of reading + 0.65 $\mu$ A 0.025 % of reading + 0.4 $\mu$ A 0.016 % of reading + 0.35 $\mu$ A 0.011 % of reading + 0.35 $\mu$ A 0.020 % of reading + 0.55 $\mu$ A 0.11 % of reading + 5 $\mu$ A	Fluke 5730A Multiproduct Calibrator; Direct Measure

**Electrical – DC/Low Frequency**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Current – Source <sup>1</sup>	(2.2 to 22) mA		Fluke 5730A Multiproduct Calibrator, Fluke 5725A Amplifier; Direct Measure
	(10 to 20) Hz	0.025 % of reading + 0.4 $\mu$ A	
	(20 to 40) Hz	0.016 % of reading + 0.35 $\mu$ A	
	40 Hz to 1 kHz	0.011 % of reading + 0.35 $\mu$ A	
	(1 to 5) kHz	0.02 % of reading + 0.55 $\mu$ A	
	(5 to 10) kHz	0.11 % of reading + 5 $\mu$ A	
	(22 to 220) mA		
	(10 to 20) Hz	0.025 % of reading + 4 $\mu$ A	
	(20 to 40) Hz	0.016 % of reading + 3.5 $\mu$ A	
	40 Hz to 1 kHz	0.011 % of reading + 2.5 $\mu$ A	
	(1 to 5) kHz	0.02 % of reading + 3.5 $\mu$ A	
	(5 to 10) kHz	0.11 % of reading + 10 $\mu$ A	
	(0.22 to 2.2) A		
	20 Hz to 1 kHz	0.025 % of reading + 35 $\mu$ A	
AC Current – Source <sup>1</sup>	(1 to 5) kHz	0.045 % of reading + 80 $\mu$ A	Fluke 5730A Multiproduct Calibrator, Fluke 52120A Current Amplifier; Direct Measure
	(5 to 10) kHz	0.7 % of reading + 0.16 mA	
	(2.2 to 11) A		
	(40 to 100) Hz	0.046 % of reading + 0.17 mA	
	(1 to 5) kHz	0.095 % of reading + 0.38 mA	
	(5 to 10) kHz	0.36 % of reading + 0.75 mA	
	Up to 2 A		
	(10 to 850) Hz	0.009 % of reading + 40 $\mu$ A	
	850 Hz to 6 kHz	0.04 % of reading + 80 $\mu$ A	
	(6 to 10) kHz	1.6 % of reading + 62 mA	
AC Current – Source <sup>1</sup>	(2 to 20) A		Comparison to Fluke 5720A Multi Product Calibrator with Fluke A40B Current Shunts
	(10 to 850) Hz	0.009 % of reading + 0.4 mA	
	850 Hz to 6 kHz	0.04 % of reading + 0.8 mA	
	(6 to 10) kHz	2.3 % of reading + 94 mA	
	(20 to 120) A		
	(10 to 850) Hz	0.009 % of reading + 2.4 mA	
	850 Hz to 6 kHz	0.04 % of reading + 4.8 mA	
	(6 to 10) kHz	3.1 % of reading + 0.7 A	
	9 $\mu$ A to 1 mA		
	DC to 10 kHz	75 $\mu$ A/A	
AC Current – Source <sup>1</sup>	1 mA to 1 A		
	DC to 10 kHz	28 $\mu$ A/A	
	(1 to 20) A		
	DC to 10 kHz	52 $\mu$ A/A	



**Electrical – DC/Low Frequency**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Current – Source <sup>1</sup>	(20 to 120) A DC to 1 kHz (1 to 6) kHz	3 mA/A 12 mA/A	Comparison to Fluke 5720A Multi Product Calibrator with Fluke A40B Current Shunts
AC Current – Measure <sup>1</sup>	9 $\mu$ A to 1 mA (DC to 30) kHz (30 to 100) kHz 1mA to 1A (DC to 100) kHz (1 to 20) A (DC to 10) kHz (10 to 30) kHz (30 to 100) kHz	90 $\mu$ A/A 0.18 mA/A 35 $\mu$ A/A 61 $\mu$ A/A 83 $\mu$ A/A 0.13 mA/A	Comparison to Fluke A40B Current Shunts
AC Current – Measure <sup>1</sup>	9 $\mu$ A to 200 $\mu$ A (1 to 10) Hz 10 Hz to 10 kHz (10 to 30) kHz (30 to 100) kHz 200 $\mu$ A to 2 mA (1 to 10) Hz 10 Hz to 10 kHz (10 to 30) kHz (30 to 100) kHz (2 to 20) mA (1 to 10) Hz 10 Hz to 10 kHz (10 to 30) kHz (30 to 100) kHz (20 to 200) mA (1 to 10) Hz 10 Hz to 10 kHz (10 to 30) kHz	0.62 mA/A 0.54 mA/A 0.94 mA/A 8.4 mA/A 0.6 mA/A 0.54 mA/A 0.94 mA/A 4.2 mA/A 0.6 mA/A 0.54 mA/A 0.94 mA/A 4.2 mA/A 0.57 mA/A 0.49 mA/A 0.83 mA/A	Comparison to Fluke 8508A 8.5 Digit Multimeter

**Electrical – DC/Low Frequency**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Current – Measure	(0.2 to 2) A		Fluke 8588A 8.5 Digit Multimeter; Direct Measure
	1 Hz to 2 kHz	0.3 mA/A + 0.1 mA	
	(2 to 10) kHz	0.56 mA/A + 0.1 mA	
	(10 to 30) kHz	0.8 mA/A + 0.1 mA	
	(2 to 20) A		
	10 Hz to 2 kHz	0.84 mA/A + 0.5 mA	
	(2 to 10) kHz	0.86 mA/A + 0.5 mA	
Resistance – Source <sup>1</sup> (Fixed Artifacts)	(20 to 30) A		Comparison to Standard Resistors
	10 Hz to 2 kHz	0.84 mA/A + 12 mA	
	(2 to 10) kHz	1.2 mA/A + 12 mA	
	0.001 $\Omega$	3.5 $\mu\Omega/\Omega$	
	0.01 $\Omega$	4.3 $\mu\Omega/\Omega$	
	0.1 $\Omega$	1.5 $\mu\Omega/\Omega$	
	1 $\Omega$	0.67 $\mu\Omega/\Omega$	
	10 $\Omega$	0.56 $\mu\Omega/\Omega$	
	100 $\Omega$	0.68 $\mu\Omega/\Omega$	
	1 k $\Omega$	0.51 $\mu\Omega/\Omega$	
	10 k $\Omega$	0.8 $\mu\Omega/\Omega$	
	100 k $\Omega$	0.57 $\mu\Omega/\Omega$	
	1 M $\Omega$	1.3 $\mu\Omega/\Omega$	
	10 M $\Omega$	14 $\mu\Omega/\Omega$	
	100 M $\Omega$	130 $\mu\Omega/\Omega$	
	1 G $\Omega$	26 $\mu\Omega/\Omega$	
	(1 to 10) G $\Omega$	0.16 % of reading	
	(10 to 100) G $\Omega$	0.54 % of reading	
	(100 to 900) G $\Omega$	0.56 % of reading	
Resistance – Measure <sup>1</sup>	1 T $\Omega$	1.6 % of reading	Comparison to Standard Resistors with Bridge and DMM
	10 T $\Omega$	1.7 % of reading	
	(10 to 100) $\mu\Omega$	0.15 % of reading	
	(0.1 to 1) m $\Omega$	15 $\mu\Omega/\Omega$	
	(1 to 10) m $\Omega$	5.1 $\mu\Omega/\Omega$	
	(10 to 100) m $\Omega$	1.8 $\mu\Omega/\Omega$	
	(0.1 to 1) $\Omega$	0.67 $\mu\Omega/\Omega$	
	(1 to 10) $\Omega$	0.56 $\mu\Omega/\Omega$	
	(10 to 100) $\Omega$	0.68 $\mu\Omega/\Omega$	
	(0.1 to 1) k $\Omega$	0.51 $\mu\Omega/\Omega$	
	(1 to 10) k $\Omega$	0.8 $\mu\Omega/\Omega$	
	(10 to 100) k $\Omega$	0.57 $\mu\Omega/\Omega$	
	(0.1 to 1) M $\Omega$	1.3 $\mu\Omega/\Omega$	
	(1 to 10) M $\Omega$	14 $\mu\Omega/\Omega$	

**Electrical – DC/Low Frequency**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Resistance – Measure <sup>1</sup>	(10 to 200) MΩ (0.2 to 2) GΩ (2 to 20) GΩ	72 μΩ/Ω + 1 kΩ 0.18 mΩ/Ω + 100 kΩ 0.67 mΩ/Ω + 10 MΩ	Comparison to Decade Resistors with Bridge and DMM
Resistance – Measure <sup>1</sup> High Voltage Mode up to 200 V	(2 to 20) MΩ (20 to 200) MΩ 200 MΩ to 2 GΩ (2 to 20) GΩ	15 μΩ/Ω + 10 Ω 60 μΩ/Ω + 1 kΩ 0.15 mΩ/Ω + 100 kΩ 0.53 mΩ/Ω + 10 MΩ	Comparison to Decade Resistors with Bridge and DMM
AC Resistance (Impedance)	(1, 500) kHz, 1 MHz 25 Ω 375 Ω (1, 250, 500) kHz, 1 MHz 6 kΩ (1, 25, 50) kHz 100 kΩ	100 μΩ/Ω 100 μΩ/Ω 100 μΩ/Ω 100 μΩ/Ω	Comparison to AC Resistor Set
Capacitance – Measure <sup>1</sup>	1 kHz 1 pF 10 pF 100 pF 1 nF 1 μF	1.9 mF/F 1.1 mF/F 1.2 mF/F 1.2 mF/F 1.2 mF/F	Comparison to QuadTech 1730 LCR Meter
Capacitance – Source <sup>1</sup> (Fixed Artifacts)	100 Hz, 1 kHz 1 pF 1 nF 10 nF 100 nF 1 μF	1.8 mF/F 0.23 mF/F 0.25 mF/F 0.21 mF/F 0.25 mF/F	Comparison to Standard Capacitors
Capacitance – Source <sup>1</sup> 10 Hz to 10 kHz 10 Hz to 3 kHz 10 Hz to 1 kHz 10 Hz to 1 kHz 10 Hz to 1 kHz (10 to 600) Hz 10 Hz to 300 Hz 10 Hz to 150 Hz 10 Hz to 120 Hz	0.19 nF to 1.1 nF (1.1 to 3.3) nF (3.3 to 11) nF (11 to 110) nF (110 to 330) nF 330 nF to 1.1 μF (1.1 to 3.3) μF (3.3 to 11) μF (11 to 33) μF	15 mF/F 8.4 mF/F 3.6 mF/F 3.6 mF/F 3.7 mF/F 3.6 mF/F 3.6 mF/F 3.6 mF/F 5.1 mF/F	Comparison to Fluke 5520A Multi Product Calibrator

**Electrical – DC/Low Frequency**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Capacitance – Source <sup>1</sup> 10 Hz to 80 Hz (0 to 50) Hz (0 to 20) Hz (0 to 6) Hz (0 to 2) Hz (0 to 0.6) Hz (0 to 0.2) Hz	(33 to 110) $\mu$ F (110 to 330) $\mu$ F 330 $\mu$ F to 1.1 mF (1.1 to 3.3) mF (3.3 to 11) mF (11 to 33) mF (33 to 110) mF	5.6 mF/F 5.6 mF/F 8.7 mF/F 5.5 mF/F 5.5 mF/F 8.5 mF/F 12 mF/F	Comparison to Fluke 5520A Multi Product Calibrator
Inductance – Measure <sup>1</sup>	100 $\mu$ H @ 1 kHz 1 mH @ 1 kHz 10 mH @ 1 kHz 100 mH @ 1 kHz 1 H @ 1 kHz	1.3 mH/H	Comparison to QuadTech 1730 LCR Meter
Inductance – Source <sup>1</sup> (Fixed Artifacts)	100 Hz 500 $\mu$ H 2 mH 20 mH 1 H 10 H 1 kHz 500 $\mu$ H 2 mH 20 mH 1 H 10 H	1.2 mH/H 1.1 mH/H 1.1 mH/H 1 mH/H 1 mH/H 1 mH/H 1 mH/H 1 mH/H 1 mH/H 1 mH/H 1 mH/H	Comparison to Standard Inductors
Oscilloscopes <sup>1</sup> Square Wave Signal 50 $\Omega$ at 1 kHz  Square Wave Signal 1 M $\Omega$ at 1 kHz  DC Voltage, 50 $\Omega$ DC Voltage, 1 M $\Omega$  Leveled Sine Wave Amplitude	40 $\mu$ V to 5 V  40 $\mu$ V to 5 V  1 mV to 5 V 1 mV to 200 V  5 mV to 5 V	1 mV/V  1 mV/V  0.26 mV/V 0.25 mV/V  15 mV/V	Comparison to Fluke 9500B/3200/9530 Oscilloscope Calibrator

**Electrical – DC/Low Frequency**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Oscilloscopes <sup>1</sup> Leveled Sine Wave Flatness (relative to 50 kHz)	4.4 mVp-p to 3 Vp-p 0.1 Hz to 300 MHz (300 to 550) MHz 4.4 mVp-p to 3.3 Vp-p 550 MHz to 1.1 GHz (1.1 to 3.2) GHz	43 mV/V 43 mV/V 52 mV/V 52 mV/V	Comparison to Fluke 9500B/3200/9530 Oscilloscope Calibrator
Time Marker (50 $\Omega$ load) Source and Period	9 ns to 55 s	0.25 $\mu$ s/s	
Rise/Fall Time – Source	150 ps	27 ps	
Pulse Width – Source	(1 to 100) ns	52 ms/s	
Electrical Simulation of Thermocouple Indicators <sup>1</sup>	Type B (250 to 350) °C	1.1 °C	Comparison to Ectron 1140A Thermocouple Simulator
	(350 to 445) °C	0.85 °C	
	(445 to 580) °C	0.67 °C	
	(580 to 750) °C	0.52 °C	
	(750 to 1 000) °C	0.43 °C	
	(1 000 to 1 820) °C	0.33 °C	
	Type C (0 to 250) °C	0.23 °C	
	(250 to 1 000) °C	0.18 °C	
	(1 000 to 1 500) °C	0.21 °C	
	(1 500 to 1 800) °C	0.24 °C	
	(1 800 to 2 000) °C	0.27 °C	
	(2 000 to 2 250) °C	0.33 °C	
	(2 250 to 2 315) °C	0.37 °C	
	Type E (-270 to -245) °C	1.38 °C	
	(-245 to -195) °C	0.21 °C	
	(-195 to -155) °C	0.12 °C	
	(-155 to -90) °C	0.09 °C	
	(-90 to 15) °C	0.08 °C	
	(15 to 890) °C	0.07 °C	
	(890 to 1 000) °C	0.08 °C	

**Electrical – DC/Low Frequency**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Electrical Simulation of Thermocouple Indicators <sup>1</sup>	Type J		Comparison to Ectron 1140A Thermocouple Simulator
	(-210 to -180) °C	0.14 °C	
	(-180 to -120) °C	0.12 °C	
	(-120 to -50) °C	0.09 °C	
	(-50 to 990) °C	0.08 °C	
	(990 to 1 200) °C	0.08 °C	
	Type K		
	(-270 to -255) °C	2.5 °C	
	(-255 to -195) °C	0.81 °C	
	(-195 to -115) °C	0.14 °C	
	(-115 to -55) °C	0.1 °C	
	(-55 to 1 000) °C	0.08 °C	
	(1 000 to 1 372) °C	0.09 °C	
	Type N		
	(-270 to -260) °C	5.8 °C	
	(-260 to -200) °C	1.2 °C	
	(-200 to -140) °C	0.27 °C	
	(-140 to -70) °C	0.17 °C	
	(-70 to 25) °C	0.14 °C	
	(25 to 160) °C	0.12 °C	
	(160 to 1 300) °C	0.1 °C	
	Type R		
	(-50 to -30) °C	0.75 °C	
	(-30 to 45) °C	0.63 °C	
	(45 to 160) °C	0.46 °C	
	(160 to 380) °C	0.35 °C	
	(380 to 775) °C	0.3 °C	
	(775 to 1 768) °C	0.25 °C	
	Type S		
	(-50 to -30) °C	0.71 °C	
	(-30 to -45) °C	0.64 °C	
	(-45 to -105) °C	0.46 °C	
	(-105 to 310) °C	0.38 °C	
	(310 to 615) °C	0.33 °C	
	(615 to 1 768) °C	0.3 °C	



**Electrical – DC/Low Frequency**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Electrical Simulation of Thermocouple Indicators <sup>1</sup>	Type T (-270 to -255) °C (-255 to -240) °C (-240 to -210) °C (-210 to -150) °C (-150 to -40) °C (-40 to 100) °C (100 to 400) °C	2.1 °C 0.56 °C 0.35 °C 0.21 °C 0.14 °C 0.09 °C 0.08 °C	Comparison to Ectron 1140A Thermocouple Simulator
Electrical Simulation of RTD Indicators <sup>1</sup>	PT 395 100 Ω (-200 to 0) °C (0 to 100) °C (100 to 300) °C (300 to 400) °C (400 to 630) °C (630 to 800) °C PT 3926 100 Ω (-200 to 0) °C (0 to 100) °C (100 to 300) °C (300 to 400) °C (400 to 630) °C PT 3916 100 Ω (-200 to -190) °C (-190 to -80) °C (-80 to 0) °C (0 to 100) °C (100 to 260) °C (260 to 300) °C (300 to 400) °C (400 to 600) °C (600 to 630) °C PT 385 200 Ω (-200 to 100) °C (100 to 260) °C (260 to 300) °C (300 to 400) °C (400 to 600) °C (600 to 630) °C	0.06 °C 0.08 °C 0.11 °C 0.12 °C 0.14 °C 0.27 °C 0.06 °C 0.08 °C 0.11 °C 0.12 °C 0.14 °C 0.29 °C 0.05 °C 0.06 °C 0.07 °C 0.08 °C 0.09 °C 0.11 °C 0.12 °C 0.27 °C 0.05 °C 0.06 °C 0.14 °C 0.15 °C 0.16 °C 0.19 °C	Comparison to Fluke 5520A Multi Product Calibrator

**Electrical – DC/Low Frequency**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Electrical Simulation of RTD Indicators <sup>1</sup>	PT 385 500 $\Omega$		Comparison to Fluke 5520A Multi Product Calibrator
	(-200 to -80) °C	0.05 °C	
	(-80 to 100) °C	0.06 °C	
	(100 to 260) °C	0.07 °C	
	(260 to 400) °C	0.09 °C	
	(400 to 600) °C	0.01 °C	
	(600 to 630) °C	0.13 °C	
	PT 395 100 $\Omega$		
	(-200 to 0) °C	0.06 °C	
	(0 to 100) °C	0.08 °C	
	(100 to 300) °C	0.11 °C	
	(300 to 400) °C	0.12 °C	
	(400 to 630) °C	0.14 °C	
	(630 to 800) °C	0.27 °C	
	PT 3926 100 $\Omega$		
	(-200 to 0) °C	0.06 °C	
	(0 to 100) °C	0.08 °C	
	(100 to 300) °C	0.11 °C	
	(300 to 400) °C	0.12 °C	
	(400 to 630) °C	0.14 °C	
	PT 3916 100 $\Omega$		
	(-200 to -190) °C	0.29 °C	
	(-190 to -80) °C	0.05 °C	
	(-80 to 0) °C	0.06 °C	
	(0 to 100) °C	0.07 °C	
	(100 to 260) °C	0.08 °C	
	(260 to 300) °C	0.09 °C	
	(300 to 400) °C	0.11 °C	
	(400 to 600) °C	0.12 °C	
	(600 to 630) °C	0.27 °C	
	PT 385 200 $\Omega$		
	(-200 to 100) °C	0.05 °C	
	(100 to 260) °C	0.06 °C	
	(260 to 300) °C	0.14 °C	
	(300 to 400) °C	0.15 °C	
	(400 to 600) °C	0.16 °C	
	(600 to 630) °C	0.19 °C	

**Electrical – DC/Low Frequency**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Electrical Simulation of RTD Indicators <sup>1</sup>	PT 385 500 $\Omega$		Comparison to Fluke 5520A Multi Product Calibrator
	(-200 to -80) $^{\circ}\text{C}$	0.05 $^{\circ}\text{C}$	
	(-80 to 100) $^{\circ}\text{C}$	0.06 $^{\circ}\text{C}$	
	(100 to 260) $^{\circ}\text{C}$	0.07 $^{\circ}\text{C}$	
	(260 to 400) $^{\circ}\text{C}$	0.09 $^{\circ}\text{C}$	
	(400 to 600) $^{\circ}\text{C}$	0.01 $^{\circ}\text{C}$	
	(600 to 630) $^{\circ}\text{C}$	0.13 $^{\circ}\text{C}$	
	PT 385 1 000 $\Omega$		
	(-200 to 0) $^{\circ}\text{C}$	0.04 $^{\circ}\text{C}$	
	(0 to 100) $^{\circ}\text{C}$	0.05 $^{\circ}\text{C}$	
	(100 to 260) $^{\circ}\text{C}$	0.06 $^{\circ}\text{C}$	
	(260 to 300) $^{\circ}\text{C}$	0.07 $^{\circ}\text{C}$	
	(300 to 600) $^{\circ}\text{C}$	0.08 $^{\circ}\text{C}$	
	(600 to 630) $^{\circ}\text{C}$	0.27 $^{\circ}\text{C}$	
	PtNi 120 $\Omega$		
	(-80 to 100) $^{\circ}\text{C}$	0.09 $^{\circ}\text{C}$	
	(100 to 260) $^{\circ}\text{C}$	0.16 $^{\circ}\text{C}$	
	Cu 427 10 $\Omega$		
	(-100 to 260) $^{\circ}\text{C}$	0.35 $^{\circ}\text{C}$	

**Electrical – RF/Microwave**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
RF Power – Measure Absolute Level <sup>1</sup>	(-36 to 20) dBm		Comparison to Agilent E9304A/N1912A Agilent N5531S Measuring Receiver with N5532A Sensor Module
	9 kHz to 6 GHz	0.16 dB	
	(20 to 30) dBm		
	(6 to 18) GHz	0.44 dB	
RF Power – Measure Absolute Level <sup>1</sup>	(18 to 26.5) GHz	0.5 dB	Comparison to Agilent N5531S Measuring Receiver with N5532A Sensor Module
	(-20 to 20) dBm		
	100 kHz to 30 MHz	0.2 dB	
	30 MHz to 2 GHz	0.21 dB	
	(1 to 18) GHz	0.31 dB	
RF Power – Measure Absolute Level <sup>1</sup>	(18 to 26.5) GHz	0.4 dB	Comparison to Agilent N5531S Measuring Receiver with 8482A Sensor
	(-30 to 20) dBm		
	100 kHz to 30 MHz	3.1 % of reading	

**Electrical – RF/Microwave**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Relative Power – Measure <sup>1</sup> 100 kHz to 26.5 GHz	(-10 to 0) dB (-20 to -10) dB (-30 to -20) dB (-40 to -30) dB (-50 to -40) dB (-60 to -50) dB (-70 to -60) dB (-80 to -70) dB	0.02 dB 0.03 dB 0.03 dB 0.05 dB 0.06 dB 0.06 dB 0.07 dB 0.07 dB	Comparison to Agilent N5531S Measuring Receiver with N5532A Sensor Module
Relative Power – Measure <sup>1</sup> 100 kHz to 26.5 GHz	(-90 to -80) dB (-100 to -90) dB (-110 to -100) dB (-120 to -110) dB (-130 to -120) dB (-140 to -130) dB	0.08 dB 0.08 dB 0.09 dB 0.1 dB 0.1 dB 0.1 dB	Comparison to Agilent N5531S Measuring Receiver with N5532A Sensor Module
RF Power – Source <sup>1</sup>	(-90 to -75) dBm 250 kHz to 2 GHz (2 to 20) GHz (20 to 32) GHz (-75 to -10) dBm 250 kHz to 2 GHz (2 to 20) GHz (20 to 32) GHz (-20 to -10) dBm 250 kHz to 2 GHz (2 to 20) GHz (20 to 32) GHz	0.73 dB 1 dB 1.2 dB 0.72 dB 1 dB 1.2 dB 1.4 dB 1.3 dB 1.3 dB	Comparison to Agilent N5183A Signal Generator
RF Power – Source <sup>1</sup>	(-10 to 10) dBm 250 kHz to 2 GHz (2 to 20) GHz (20 to 32) GHz > 10 dBm 250 kHz to 2 GHz (2 to 20) GHz (20 to 32) GHz	0.61 dB 0.91 dB 0.93 dB 0.63 dB 0.92 dB 1 dB	Comparison to Agilent N5183A Signal Generator
Phase Modulation – Source <sup>1</sup> 100 kHz to 32 GHz	Rate: DC to 1 MHz DC to 4 MHz	0.59 % of reading + 0.01 rad	Comparison to Agilent N5183A Signal Generator

**Electrical – RF/Microwave**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
LO Phase Noise @ 1GHz	(-50 to 20) dB Frequency offset: (0.10 to 1 000) Hz (1 to 9 900) kHz	0.48 dB 0.64 dB	Comparison to Keysight E4440A Spectrum Analyzer
Amplitude Modulation <sup>1</sup> - Source 100 kHz to 32 GHz	Rate: DC to 10 kHz Depths: (1 to 90) %	4.1 % of reading	Comparison to Agilent N5183A Signal Generator
Amplitude Modulation – Measure <sup>1</sup> 100 kHz to 10 MHz	Rate: 20 Hz to 10 kHz Depths: (5 to 99) %	0.83 % of reading	Comparison to Agilent N5531S Measuring Receiver with N5532A Sensor Modules
10 MHz to 3 GHz	Rate: 50 Hz to 100 kHz Depths: (20 to 99) %	0.59 % of reading	
10 MHz to 3 GHz	Rate: 50 Hz to 100 kHz Depths: (5 to 20) %	2.6 % of reading	
(3 to 26.5) GHz	Rate: 50 Hz to 100 kHz Depths: (20 to 99) %	1.6 % of reading	
(3 to 26.5) GHz	Rate: 50 Hz to 100 kHz Depths: (5 to 20) %	4.7 % of reading	
Pulse Generation – Source <sup>1</sup> Repetition Frequency: 0.1 Hz to 10 MHz	30 ns to 42 s	10 ns	Comparison to Agilent N5183A Signal Generator
Frequency Modulation – Source <sup>1</sup> 100 kHz to 32 GHz	1 dB Rate: DC to 3 MHz 3 dB Rate: DC to 7 MHz	2 % of setting + 20 Hz	Comparison to Agilent N5183A Signal Generator

**Electrical – RF/Microwave**

**Burnsville, MN**

<b>Parameter/Equipment</b>	<b>Range</b>	<b>Expanded Uncertainty of Measurement (+/-)</b>	<b>Reference Standard, Method, and/or Equipment</b>
Phase Modulation-Measure <sup>1</sup> 100 kHz to 6.6 GHz	Rate: 200 Hz 20 kHz Dev.: > 0.7 rad	1.1 % of reading	Comparison to Agilent N5531S Measuring Receiver with N5532A Sensor Modules
100 kHz to 6.6 GHz	Rate: 200 Hz, 20 kHz Dev.: > 0.3 rad	3.1 % of reading	
(6.6 to 13.2) GHz	Rate: 200 Hz 20 kHz Dev.: > 2.0 rad	1.1 % of reading	
(6.6 to 13.2) GHz	Rate: 200 Hz 20 kHz Dev.: > 0.6 rad	3.1 % of reading	
(13.2 to 26.5) GHz	Rate: 200 Hz 20 kHz Dev.: > 2.0 rad	1.1 % of reading	
(13.2 to 26.5) GHz	Rate: 200 Hz 20 kHz Dev.: > 0.6 rad	3.1 % of reading	
Freq Modulation – Measure <sup>1</sup> Freq. Dev. Mod Rate Ratio > 0.2 250 kHz to 10 MHz	Rate: 20 Hz to 10 kHz Dev.: 200 Hz to 40 kHz peak Freq. Dev. Mod Rate Ratio > 0.2	1.6 % of reading	Comparison to Agilent N5531S Measuring Receiver with N5532A Sensor Modules
250 kHz to 10 MHz	Rate: 20 Hz to 10 kHz Dev.: 200 Hz to 40 kHz peak Freq. Dev. Mod Rate Ratio > 1.2	1.1 % of reading	
10 MHz to 6.6 GHz	Rate: 50 Hz to 200kHz Dev.: 250 Hz to 400 kHz peak Freq. Dev. Mod Rate Ratio > 0.2	1.6 % of reading	



**Electrical – RF/Microwave**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Freq Modulation – Measure <sup>1</sup> Freq. Dev. Mod Rate Ratio > 0.2 10 MHz to 6.6 GHz	Rate: 50 Hz to 200kHz Dev.: 250 Hz to 400 kHz peak Freq. Dev. Mod Rate Ratio > 0.45	1.1 % of reading	Comparison to Agilent N5531S Measuring Receiver with N5532A Sensor Modules
(6.6 to 13.2) GHz	Rate: 50 Hz to 200kHz Dev.: 250 Hz to 400 kHz peak Freq. Dev. Mod Rate Ratio > 0.2	2.6 % of reading	
(6.6 to 13.2) GHz	Rate: 50 Hz to 200kHz Dev.: 250 Hz to 400 kHz peak Freq. Dev. Mod Rate Ratio > 8	1.1 % of reading	
(13.2 to 26.5) GHz	Rate: 50 Hz to 200kHz Dev.: 250 Hz to 400 kHz peak Freq. Dev. Mod Rate Ratio > 0.2	3.9 % of reading	
(13.2 to 26.5) GHz	Rate: 50 Hz to 200kHz Dev.: 250 Hz to 400 kHz peak	1.1 % of reading	

**Length – Dimensional Metrology**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Angle Measuring Equipment <sup>2</sup>	(0.25 to 365)°	2.4"	Comparison to Gage Blocks, Gage Amplifier, Sine Bar
Angle Plates – Squareness <sup>2</sup>	Up to 18 in	0.000 32° (5.6 µin/in)	Comparison to Gage Amplifier with probe, Master Square(s)
Gage Blocks <sup>2</sup>	(0.01 to 1) in (2 to 3) in 4 in	(1.1 + 0.4L) µin (1.2 + 0.7L) µin 4.6 µin	Comparison to Master Gage Blocks, Gage Block Comparator

**Length – Dimensional Metrology**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Gage Blocks <sup>2</sup>	(5 to 20) in	$(0.96 + 1.2L) \mu\text{in}$	Comparison to Horizontal Measuring Machine
Gage Blocks <sup>2</sup>	100 mm (125 to 500) mm	$0.17 \mu\text{m}$ $(0.06 + 0.000 6L) \mu\text{m}$	Comparison to Primary Master Gage Blocks
Indicators <sup>1,2</sup>	(0.000 1 to 6) in	$(5 + 8L) \mu\text{in}$	Comparison to Horizontal Measuring Machine
Calipers <sup>1,2</sup>	Up to 60 in (60 to 80) in	$(5 + 8L) \mu\text{in}$ $(410 + 2L) \mu\text{in}$	Comparison to Gage Blocks
Outside Micrometers <sup>1,2</sup> Linearity	Up to 12 in (12 to 24) in	$(5 + 8L) \mu\text{in}$ $(34 + 4.6L) \mu\text{in}$	Comparison to Gage Blocks
Anvil Flatness	Up to 1 inD (0 to 84) $\mu\text{in}$	4 $\mu\text{in}$	Optical Parallels
Height Measuring Devices <sup>1,2</sup>	Up to 36 in (36 to 48) in	$(43 + 1.7L) \mu\text{in}$ $(7 + 3L) \mu\text{in}$	Comparison to Gage Blocks
Grind Gages	Up to 100 mm	0.35 mm	Comparison to Digital Indicator
Coating Thickness Gages <sup>1,2</sup>	Up to 0.02 in	$58 \mu\text{in} + 0.6R$	Comparison to Coating Thickness Standards
Coating Thickness Gage Standards	Up to 0.10 in	21 $\mu\text{in}$	Comparison to Horizontal Measuring Machine
External Diameter <sup>1,2</sup>	(0.000 1 to 1) in (1 to 12) in	$(3 + 1L) \mu\text{in}$ $(3 + 3L) \mu\text{in}$	Comparison to Horizontal Measuring Machine
Internal Diameter <sup>1,2</sup>	(0.04 to 13) in	$(3 + 3L) \mu\text{in}$	Comparison to Horizontal Measuring Machine
Thread Plugs <sup>1,2</sup> Pitch Diameter	Up to 8 in Pitch (0.2 to 5) mm	$(81 + 2.3L) \mu\text{in}$	Comparison to Horizontal Measuring Machine
Major Diameter	Pitch 90 – 4 TPI Up to 4 in	$(3.5 + 4.6L) \mu\text{in}$	Thread Measuring Wires

**Length – Dimensional Metrology**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Thread Rings (Adjustable) Pitch Diameter Tactile Fit (Set to Plug)	Up to 4 in	See footnote <sup>5</sup>	Comparison to Thread Setting Plug
Optical Comparators <sup>1,2</sup> Linear Accuracy	Up to 6 in 6 to 12 in	(43 + 11L) μin (30 + 7.5L) μin	Comparison to Glass Scale
Magnification	(5 to 100) X	350 μin	Glass Scale (Sphere)
Surface Plates <sup>1,2</sup> Overall Flatness	Up to 54 inDL (54 to 238) inDL	(17 + 0.7DL) μin (1 + 1.4DL) μin	Comparison to Laser System
Local Area Flatness	Up to 238 inDL	34 μin	Repeat-O-Meter
Roundness/Cylindricity Artifacts	Up to 150 mm	0.02 μm	Comparison to Rondcom41c
Surface Finish Artifacts	Up to 118 μin 118.1 to 500 μin	0.5 μin + 1 % of nominal 0.6 μin + 1.1 % of nominal	Comparison to Profilometer, Master Patch
Profilometers <sup>1</sup>	Up to 500 μin	0.7 μin + 1.1 % of nominal	Comparison to Master Patch
Optical Flats Parallelism	Up to 6 inD (0 to 80) μin	2.7 μin	Comparison to Gage Block Comparator, Master Flat
Flatness	Up to 6 inD (0 to 80) μin	3.5 μin	
CMMs <sup>1,2</sup> Linearity	Up to 144 in	(25 + 2.4L) μin	Comparison to Laser Measuring System
Volumetric Repeatability	(6 to 24) in (0.5 to 2) in	66 μin 45 μin	Ball Bar, CMM Sphere
VMMs <sup>1,2</sup> X,Y Linearity	Up to 12 in	(32 + 4.1L) μin	Comparison to Glass Scales
Graduated Scales <sup>1,2</sup> Glass, Steel, Tape	Up to 12 in (1 to 200) ft	(40 + 1L) μin (10+ 3L) μin	Comparison to Laser Measuring System
Horizontal Measuring Systems <sup>1,2</sup>	Up to 8 in (8 to 60) in	(6 + 1.7L) μin (3 + 2.5L) μin	Comparison to Gage Blocks

## Length – Dimensional Metrology

Burnsville, MN

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Bore Gages <sup>2,7</sup> 2-point	(0.24 to 9) in	$(4.3 + 3L) \mu\text{in}$	Comparison to Horizontal Measuring Machine
3-point	(0.24 to 9) in	$(85 + 7L) \mu\text{in}$	Cylindrical Rings
Protractors	(0 to 90)°	0.16°	Comparison to Sine Bar, Gage Blocks
Chamfer Gages <sup>2,7</sup>	(0.179 to 2.749) in	280 $\mu\text{in}$	Comparison to Chamfer Rings
Cylindrical Squares <sup>2</sup> Squareness	Up to 12 in	1.5"	Comparison to Gage Amplifier w/ probe, Master Square(s)
Cylindricity	-	0.02 $\mu\text{m}$	Roundness Machine
Feeler/Thickness Gages <sup>2</sup>	Up to 0.2 in	$(4.3 + 3L) \mu\text{in}$	Comparison to Horizontal Measuring System
Gage Amplifier w/ Probe(s)	Up to 0.1 in	10 $\mu\text{in}$	Comparison to Gage Blocks
Gage Balls/Spheres <sup>2</sup> Diameter	Up to 6 in	$(4.3 + 3D) \mu\text{in}$	Comparison to Gage Blocks, Horizontal Measuring System
Roundness	-	0.02 $\mu\text{m}$	Roundness Machine
Indicator Calibrator <sup>7</sup> (Linearity)	Up to 6 in	60 $\mu\text{in}$	Comparison to Horizontal Measuring System
Groove Micrometers <sup>2,7</sup>	Up to 12 in	$(44 + 2.6L) \mu\text{in}$	Comparison to Gage Blocks
Machinist Levels <sup>2</sup> Zero Check	Up to 24 in	350 $\mu\text{in}$	Comparison to Master Level, Gage Blocks
Linearity	-	$(100 + 0.83L) \mu\text{in}$	
Microscopes, Stereo Reticle Linearity	Up to 2 in	870 $\mu\text{in}$	Comparison to Stage Micrometer
Toolmakers Microscope <sup>2,7</sup> Scale Linearity	Up to 4 in	$(774 + 70L) \mu\text{in}$	Comparison to Stage Micrometer
Length Standards <sup>2</sup>	(1 to 60) in	$(3.4 + 3.5L) \mu\text{in}$	Comparison to Horizontal Measuring System

**Length – Dimensional Metrology**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Inside Micrometers <sup>2</sup>	Up to 8 in (8 to 60) in	$(6 + 1.7L) \mu\text{in}$ $(3 + 2.5L) \mu\text{in}$	Comparison to Horizontal Measuring System
Pi Tapes <sup>2</sup>			
Length	Up to 12 in	$(40 + 1L) \mu\text{in}$ $(10 + 3L) \mu\text{in}$	Comparison to Laser System
Thickness	(12 to 200) in	240 $\mu\text{in}$	Micrometer
Parallels <sup>2</sup>			
Steel	Up to 18 in	$(96 + 1.8L) \mu\text{in}$	Comparison to Electronic Amplifier with Probe, Surface Plate
Granite	Up to 18 in	$(49 + 0.7L) \mu\text{in}$	
Pitch Micrometer Standard <sup>2</sup>			
Length	(1 to 65) in	$(3.4 + 3.5L) \mu\text{in}$	Comparison to Horizontal Measuring System
Angle	60°	0.004° (70 $\mu\text{in/in}$ )	Vision System
Radius Gages	(0.015 625 to 0.5) in	300 $\mu\text{in}$	Comparison to Vision System
Sine Plates/Bars <sup>2</sup> – Top Surface Flatness	Up to 0.1 in	$(41 + 2.2L) \mu\text{in}$	Comparison to Electronic Amplifier with Probe
Overall Length	Up to 10 in	$(3.4 + 3.5L) \mu\text{in}$	Horizontal Measuring System
Squares <sup>2</sup>	Up to 18 in	0.000 32° (5.6 $\mu\text{in/in}$ )	Comparison to Electronic Amplifier with Probe, Master Square
Straight Edges <sup>2</sup> (Straightness)	Up to 60 in	$(208 + 2.3L) \mu\text{in}$	Comparison to Electronic Amplifier with Probe, Surface Plate
Tapered Plugs <sup>2</sup>			
Pitch Diameter	(0.062 5 to 6) in	$(137 + 3.3L) \mu\text{in}$	Comparison to Horizontal Measuring System,
Major Diameter	(0.062 5 to 6) in	$(123 + 6.7L) \mu\text{in}$	Sine Block, Thread Wires,
Step Height	-	280 $\mu\text{in}$	Height Gage

## Length – Dimensional Metrology

Burnsville, MN

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Roundness Machine Roundness (Spindle Performance)	Up to 0.016 in	15 $\mu$ in	Comparison to Master Sphere
Tapered Rings Pitch Diameter	(0.0625 to 6) in	160 $\mu$ in	Comparison to NPT Master Plug, Electronic Amplifier with Probe
Step Height	-	5 $\mu$ in	Height Gage
Thickness Gages <sup>2,7</sup> Dial	Up to 1 in	410 $\mu$ in	Comparison to Gage Blocks
Digital	Up to 1 in	44 $\mu$ in	
Thread Micrometers <sup>2</sup> (Screw Thread, Pitch Point) Linearity <sup>7</sup>	Up to 12 in	(44 + 2.6L) $\mu$ in	Comparison to Gage Blocks, Thread Setting Plug
Anvil Wear	-	690 $\mu$ in	
Granite V Blocks – Side Parallelism, V Parallelism, Squareness <sup>2</sup>	Up to 12 in	(51 + 0.47L) $\mu$ in	Comparison to Electronic Amplifier with Probe, Surface Plate
Extensometers <sup>1</sup>	Up to 2 in	16 $\mu$ in	Comparison to Extensometer Calibrator
Extensometers <sup>1</sup> Gage Length	(0 to 2) in	78 $\mu$ in	Comparison to Caliper

## Mass and Mass Related

Burnsville, MN

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Force <sup>1</sup> Source and Measure	(0.035 to 16) ozf (1 to 10) lbf (10 to 50) lbf (50 to 500) lbf	0.017 % of reading 0.018 % of reading 0.018 % of reading 0.036 % of reading	Comparison to Dead Weights
Force <sup>1</sup> Source and Measure	(500 to 100 000) lbf	0.04 % of reading	



**Mass and Mass Related**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Force <sup>1</sup> Source and Measure	(30 000 to 400 000) lbf	0.29 % of applied value	Comparison to Load Cells, Class A (compression only)
Test Machine Crosshead Displacement <sup>1,2</sup>	Up to 1 in (1 to 36) in	0.000 3 in (150 + 146L) µin	Comparison to Indicator Indicator with Gage Blocks
Cable Tensiometers	Up to 600 lb (600 to 2 000) lb	1.2 % of applied value 1.3 % of applied value	Comparison to Dead Weight Load Cells
Viscometers <sup>1</sup>	Up to 25 cP (25 to 1 500) cP (1 500 to 75 000) cP	0.33 % of reading 0.52 % of reading 0.55 % of reading	Comparison to Viscosity Standards
Pressure <sup>1</sup> (Absolute)	(10 to 17) psia	0.000 4 psi	Comparison to Pressure Calibrator
Pressure (Gauge)	(-14.5 to -0.5) psi (1 to 500) psi (500 to 10 000) psi	0.006 5 % of reading 0.006 5 % of reading 0.007 % of reading	Comparison to Dead Weight Tester
Pressure (Gauge)	(0 to 2) inH <sub>2</sub> O (2 to 60) inH <sub>2</sub> O	0.000 35 inH <sub>2</sub> O 0.009 1 % of reading + 0.000 3 inH <sub>2</sub> O	Comparison to Fluke 7250LP Low Pressure Calibrator
Mass Flow (Gas)	(1 to 10) sccm (10 to 50 000) sccm  (50 to 500) slpm	0.22 % of reading 0.17 % of reading  0.2 % of reading	Comparison to Fluke molbloc Flow Calibration System Mesa Flow System
Air Velocity	30 ft/min (40 to 60) ft/min (60 to 150) ft/min (150 to 275) ft/min (275 to 9000) ft/min	5.1 % of reading 2.6 % of reading 1.2 % of reading 0.99 % of reading 0.74 % of reading	Comparison to Wind Tunnel with Pitot Tube
Torque Tools <sup>1</sup>	(2 to 20) ozf·in (20 to 200) ozf·in (5 to 50) lbf·in (50 to 400) lbf·in (400 to 1000) lbf·in (80 to 250) lbf·ft (250 to 600) lbf·ft (600 to 2 000) lbf·ft	0.1 % of reading + 0.006 1 ozf·in 0.08% of reading + 0.14 ozf·in 0.33 % of reading 0.36 % of reading 0.4 % of reading 0.28 % of reading 0.51 % of reading 0.75 % of reading	Comparison to Torque Tester

**Mass and Mass Related**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Torque Transducers <sup>1</sup>	0.5 ozf-in to 1 000 lbf-ft (1 000 to 2 000) lbf-ft	0.08 % of reading 0.09 % of reading	Comparison to Dead Weights, Torque Arms
Graduated Cylinders	(1 to 200) mL (100 to 1 000) mL (600 to 6 000) mL	1.9 µL 3.2 µL 26 µL	Comparison to Balances
Pipettes	Up to 1 µL (1 to 5) µL (5 to 10) µL (10 to 20) µL (20 to 50) µL (50 to 100) µL (100 to 200) µL (200 to 500) µL (500 to 1 000) µL (1 000 to 10 000) µL (10 to 20) mL	0.041 µL 0.033 µL 0.028 µL 0.034 µL 0.046 µL 0.061 µL 0.27 µL 0.3 µL 0.79 µL 2.7 µL 5.8 µL	Comparison to Pipette Calibration System
Scales and Balances <sup>1,6</sup>	Up to 5 mg (5 to 500) mg 500 mg to 5 g (5 to 10) g (10 to 20) g (20 to 50) g (50 to 100) g (100 to 250) g	5 µg 6 µg 7 µg 12 µg 14 µg 24 µg 86 µg 92 µg	Comparison to OIML Class E2, ASTM E617 Class 1 Weights, and internal calibration procedure utilized in the calibration of the weighing system.
Scales and Balances <sup>1,6</sup>	250 g to 1.1 kg (1.1 to 6.1) kg (6.1 to 33) kg	1.4 mg 9 mg 90 mg	Comparison to OIML Class E2, ASTM E617 Class 1 Weights, and internal calibration procedure utilized in the calibration of the weighing system.
Scales and Balances <sup>1,6</sup>	(0.5 to 2 000) lb	0.01 % of reading	Comparison to ASTM Class E617 Class 6 Weights and internal calibration procedure utilized in the calibration of the weighing system.

**Mass and Mass Related**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Mass	1 mg to 50 g (50 to 100) g (100 to 250) g (250 to 500) g (500 to 1 kg (1 to 6) kg (6 to 25) kg	0.01 mg 0.03 mg 0.12 mg 0.17 mg 0.9 mg 9 mg 90 mg	Comparison to Class 1 Weights, Balances
Micro-indentation Hardness Testers <sup>1</sup> (Knoop and Vickers)	Repeatability under forces (gf): 100 ≤ HK ≤ 500 HV = 100	2.1 % of Reading 4.1 % of Reading	Indirect Verification to Hardness Test Blocks
Brinell Hardness Testers <sup>1</sup>	Repeatability at: 500 kgf ≤ 100 HBW ≥ 64 HBW 1 500 kgf ≤ 257 HBW ≥ 91 HBW 3 000 kgf ≤ 587 HBW ≥ 186 HBW	0.025 mm 0.025 mm 0.025 mm 0.03 mm 0.025 mm 0.025 mm	Indirect Verification to Hardness Test Blocks
Rockwell Hardness Testers <sup>1</sup>	HRA Low HRA Middle HRA High  HRBW Low HRBW Middle HRBW High  HRC Low HRC Middle HRC High  HREW Low HREW Middle HREW High  HRMW Low HRMW Middle HRMW High	0.69 HRA 0.62 HRA 0.36 HRA  0.71 HRBW 0.53 HRBW 0.9 HRBW  0.54 HRC 0.7 HRC 1.2 HRC  0.49 HREW 0.39 HREW 0.88 HREW  0.65 HRMW 0.55 HRMW 0.65 HRMW	Indirect Verification to Hardness Test Blocks

**Mass and Mass Related**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Rockwell Hardness Testers <sup>1</sup>	HR15N Low	0.69 HR15N	Indirect Verification to Hardness Test Blocks
	HR15N Middle	0.69 HR15N	
	HR15N High	0.36 HR15N	
	HR15TW Low	0.87 HR15TW	
	HR15TW Middle	0.72 HR15TW	
	HR15TW High	0.72 HR15TW	
	HR30N Low	0.87 HR30N	
	HR30N Middle	0.91 HR30N	
	HR30N High	0.36 HR30N	
	HR30TW Low	0.54 HR30TW	
	HR30TW Middle	0.72 HR30TW	
	HR30TW High	0.39 HR30TW	
Durometers	HR45N Low	0.64 HR45N	Full Verification using Shore Durometer Calibrator, Balance
	HR45N Middle	1.2 HR45N	
	HR45N High	0.34 HR45N	
	HR45TW Low	0.92 HR45TW	
	HR45TW Middle	0.92 HR45TW	
	HR45TW High	0.61 HR45TW	
	Spring Force		
	Types A, B, E, O	Up to 100 Duro	
	Types C, D, and DO	Up to 100 Duro	
	Types M, OO, OOO, OOO-S	Up to 100 Duro	
	Indenter Dimensions		
	Angle	(20 to 40)°	
	Length	(0.049 to 0.198) in	
	Radius	(0.05 to 0.1) in	
		0.004°	Video Measuring Machine
		220 μin	
		250 μin	

**Thermodynamic**

**Burnsville, MN**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Temperature – Measure	(-200 to -20) °C (-20 to 120) °C (120 to 200) °C (200 to 300) °C (300 to 660) °C	0.006 2 °C 0.001 7 °C 0.023 °C 0.023 °C 0.024 °C	Comparison to Fluke 5699 SPRT, Fluke 1590 Super Thermometer
Temperature – Source (Measuring Devices)	(-95 to -20) °C (-20 to 120) °C (120 to 425) °C (425 to 660) °C	0.032 °C 0.001 7 °C 0.038 °C 0.063 °C	Comparison to SPRT, Fluke 1590 Super Thermometer, Liquid Baths, Metrology Well
Radiation (Infrared) Thermometers	(-15 to 0) °C (0 to 100) °C (100 to 200) °C (200 to 350) °C (350 to 500) °C	0.54 °C 0.69 °C 1.1 °C 1.6 °C 2.4 °C	Comparison to Fluke 4180 / 4181 Black Body Calibrators (flat-plate) $\lambda = (8 \text{ to } 14) \mu\text{m}$ , $\epsilon = (0.9 \text{ to } 1)$
Humidity – Measure <sup>1</sup>	(0 to 2) %RH (5 to 10) %RH (10 to 50) %RH (50 to 90) %RH (90 to 95) %RH	1.2 %RH 0.56 %RH 0.5 %RH 0.55 %RH 0.58 %RH	Comparison to Humidity Indicator
Humidity – Source	0 %RH (5 to 10) %RH (10 to 98) %RH	0.62 %RH 0.56 %RH 0.5 % of reading	Comparison to Nitrogen with Rotronic Humidity Indicator, Thunder Scientific 2900 Two-Pressure Generating System
Temperature Uniformity Survey <sup>1</sup> (TUS)	Up to 200 °F (200 to 1 000) °F (1 000 to 1 400) °F (1 400 to 1 800) °F (1 800 to 2 000) °F (2 000 to 2 300) °F	1.6 °F 1.8 °F 2.1 °F 2.9 °F 4.1 °F 4.3 °F	Comparison to Temperature Datalogger, Type K Thermocouples per AMS 2750.

## Time and Frequency

Burnsville, MN

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Frequency – Reference <sup>4</sup>	10 MHz	$5 \times 10^{-11}$ MHz	Comparison to SRS FS Rubidium GPS Disciplined Oscillator

## DIMENSIONAL MEASUREMENT

### 2 Dimensional

Burnsville, MN

Specific Tests and / or Properties Measured	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method and/or Equipment
Angle	(0.25 to 365)°	0.000 69° (12 μin/ in)	Comparison to Gage Blocks, Gage Amplifier, Sine Bar
Angle	(0.25 to 365)°	0.004°	Comparison to Coordinate Measuring Machine
2D – Non-contact	(12 x 8 x 4) in	(44 + 1L) μin	Comparison to Vision System
Roundness, Cylindricity	Up to 150 mm	0.02 μm	Comparison to Rondcom41c
Surface Finish Analysis	Up to 118 μin (118.1 to 500) μin	1 % of reading + 0.5 μin 1.1 % of reading + 0.6 μin	Comparison to Profilometer, Master Patch

### 3 Dimensional

Burnsville, MN

Specific Tests and / or Properties Measured	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method and/or Equipment
Dimensional Inspection Contact <sup>1</sup>	(500 x 700 x 500) mm	(0.92 + 0.002 8L) μm	Comparison to Coordinate Measuring Machine

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### Services performed at satellite laboratory

1208 Allanson Road,

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### CALIBRATION

#### Chemical Quantities

Mundelein, IL

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
pH Meters <sup>1</sup>	4 pH 7 pH 10 pH	0.016 pH 0.016 pH 0.016 pH	Comparison to Buffer Solutions

#### Electrical – DC/Low Frequency

Mundelein, IL

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
DC Voltage – Source <sup>1</sup> (Fixed Artifact)	10 V	0.3 $\mu$ V/V	Comparison to Fluke 732B Voltage Standards with Fluke Maps
DC Voltage – Source <sup>1</sup>	0V Up to 1 mV (1 to 10) mV (10 to 100) mV (100 mV to 1) V (1 to 10) V (10 to 100) V (100 to 1 100) V	20 nV 100 nV 22 $\mu$ V/V + 25 nV 5.3 $\mu$ V/V 0.5 $\mu$ V/V 0.31 $\mu$ V/V 0.35 $\mu$ V/V 1 $\mu$ V/V	Comparison to MI Potentiometer/ Divider And Fluke 5720A Multi Product Calibrator
DC Voltage – Measure <sup>1</sup>	0V Up to 1 mV (1 to 10) mV (10 to 100) mV (100 mV to 1) V (1 to 10) V (10 to 100) V (100 to 1 100) V	20 nV 100 nV 22 $\mu$ V/V + 25 nV 5.3 $\mu$ V/V 0.5 $\mu$ V/V 0.31 $\mu$ V/V 0.35 $\mu$ V/V 1 $\mu$ V/V	Comparison to Nano Voltmeter, Fluke 732B Voltage Standard with MI Potentiometer/ Divider
DC Voltage – Measure <sup>1</sup>	(1.05 to 100) kV	0.1 % of reading	Comparison to Hipotronics KVM100-A High Voltage Meter



**Electrical – DC/Low Frequency**

**Mundelein, IL**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
DC Current – Source & Measure <sup>1</sup>	Up to 100 nA (0.1 to 1) $\mu$ A (1 to 10) $\mu$ A (10 to 100) $\mu$ A (0.1 to 1) mA (1 to 10) mA (10 to 100) mA (0.1 to 1) A	22 pA 30 $\mu$ A/A 6.8 $\mu$ A/A 6.2 $\mu$ A/A 4.1 $\mu$ A/A 4.2 $\mu$ A/A 3.9 $\mu$ A/A 17 $\mu$ A/A	Comparison to Standard Resistors and DMM, Multifunction Calibrator
DC Current – Source & Measure <sup>1</sup>	(1 to 10) A (10 to 20) A (20 to 100) A	80 $\mu$ A/A + 80 $\mu$ A 80 $\mu$ A/A + 800 $\mu$ A 80 $\mu$ A/A + 40 mA	Comparison to Fluke 52120A Amplifier
DC Current – Source <sup>1</sup>	(100 to 150) A (150 to 1 025) A	5 mA/A + 20 mA 5.1 mA/A + 0.9 A	Comparison to Fluke 5520A Multi Product Calibrator with 50-turn Coil
AC Voltage – Source & Measure <sup>1</sup>	Up to 2.2 mV (10 to 20) Hz (20 to 40) Hz (0.04 to 20) kHz (20 to 50) kHz (50 to 100) kHz (100 to 300) kHz (300 to 500) kHz (0.5 to 1) MHz (2.2 to 7) mV (10 to 20) Hz (20 to 40) Hz (0.04 to 20) kHz (20 to 50) kHz (50 to 100) kHz (100 to 300) kHz (300 to 500) kHz (0.5 to 1) MHz	0.035 % of reading + 1.3 $\mu$ V 0.037 % of reading + 1.3 $\mu$ V 0.04 % of reading + 1.3 $\mu$ V 0.025 % of reading + 2 $\mu$ V 0.027 % of reading + 2.5 $\mu$ V 0.033 % of reading + 4 $\mu$ V 0.036 % of reading + 8 $\mu$ V 0.02 % of reading + 8 $\mu$ V 0.023 % of reading + 1.3 $\mu$ V 0.024 % of reading + 1.3 $\mu$ V 0.022 % of reading + 1.3 $\mu$ V 0.014 % of reading + 2 $\mu$ V 0.009 % of reading + 2.5 $\mu$ V 0.029 % of reading + 4 $\mu$ V 0.055 % of reading + 8 $\mu$ V 0.056 % of reading + 8 $\mu$ V	Comparison to Fluke 5790A AC Standard w/ Fluke 5720A Multi Product Calibrator
AC Current – Source and Measure <sup>1</sup>	Up to 10 mA (0.01 to 100) kHz (10 to 20) mA (0.01 to 100) kHz (20 to 200) mA (0.01 to 100) kHz	250 $\mu$ A/A  250 $\mu$ A/A  250 $\mu$ A/A	Comparison to Fluke 5720A Multi Product Calibrator, Fluke 5725A Amplifier, with A40B Current Shunts

**Electrical – DC/Low Frequency**

**Mundelein, IL**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Current – Source and Measure <sup>1</sup>	(0.2 A to 20) A 0.01 to 1) kHz (1 to 10) kHz (10 to 30) kHz (30 to 100) kHz	250 $\mu$ A/A 250 $\mu$ A/A 300 $\mu$ A/A 350 $\mu$ A/A	Comparison to Fluke 5720A Multi Product Calibrator, Fluke 5725A Amplifier with A40B Current Shunts
AC Current – Source and Measure <sup>1</sup>	(20 to 100) A	0.015 % of reading	Comparison to Fluke 52120A Amplifier
AC Current – Source <sup>1</sup>	(45 to 65) Hz (10 to 16.5) A (16.5 to 150) A (150 to 1 025) A (65 to 440) Hz (10 to 16.5) A (16.5 to 150) A (150 to 1 025) A	5.9 mA/A + 30 mA 5.7 mA/A + 25 mA 5.7 mA/A + 0.9 A  11 mA/A + 30 mA 10 mA/A + 0.25 A 13 mA/A + 0.9 A	Comparison to Fluke 5520A Multi Product Calibrator with 50-turn Coil
AC Current – Measure <sup>1</sup>	Up to 200 $\mu$ A (1 to 10) Hz 10 Hz to 10 kHz (10 to 30) kHz (30 to 100) kHz 200 $\mu$ A to 2 mA (1 to 10) Hz 10 Hz to 10 kHz (10 to 30) kHz (30 to 100) kHz (2 to 20) mA (1 to 10) Hz 10 Hz to 10 kHz (10 to 30) kHz (30 to 100) kHz (20 to 200) mA (1 to 10) Hz 10 Hz to 10 kHz (10 to 30) kHz 200 mA to 2 A 10 Hz to 2 kHz (2 to 10) kHz (10 to 30) kHz	0.62 mA/A 0.54 mA/A 0.94 mA/A 8.4 mA/A  0.6 mA/A 0.54 mA/A 0.94 mA/A 4.2 mA/A  0.6 mA/A 0.54 mA/A 0.94 mA/A 4.2 mA/A  0.57 mA/A 0.49 mA/A 0.83 mA/A  0.83 mA/A 0.93 mA/A 3.2 mA/A	Comparison to Fluke 8508A 8.5 Digit Multimeter

**Electrical – DC/Low Frequency**

**Mundelein, IL**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Current – Measure <sup>1</sup>	(2 to 20) A 10 Hz to 2 kHz (2 to 10) kHz	1 mA/A 2.7 mA/A	Comparison to Fluke 8508A 8.5 Digit Multimeter
Resistance – Source <sup>1</sup> (Fixed Artifacts)	0.001 $\Omega$ 0.01 $\Omega$ 0.1 $\Omega$ 1 $\Omega$ 10 $\Omega$ 100 $\Omega$ 1 k $\Omega$ 10 k $\Omega$ 100 k $\Omega$ 1 M $\Omega$ 10 M $\Omega$ 100 M $\Omega$ 1 G $\Omega$	3.5 $\mu\Omega/\Omega$ 4.3 $\mu\Omega/\Omega$ 1.5 $\mu\Omega/\Omega$ 0.85 $\mu\Omega/\Omega$ 0.66 $\mu\Omega/\Omega$ 1.7 $\mu\Omega/\Omega$ 1.2 $\mu\Omega/\Omega$ 2.4 $\mu\Omega/\Omega$ 0.57 $\mu\Omega/\Omega$ 1.3 $\mu\Omega/\Omega$ 14 $\mu\Omega/\Omega$ 130 $\mu\Omega/\Omega$ 0.32 $\mu\Omega/\Omega$	Comparison to Standard resistors
Resistance – Source <sup>1</sup> (Variable Artifacts)	(0.01 to 10) M $\Omega$ (0.01 to 10) G $\Omega$	10 $\mu\Omega/\Omega$ 0.5 % of reading	Comparison to Decade Resistors with Bridge, DMM
Resistance – Source <sup>1</sup> (Variable Artifact)	(10 to 100) G $\Omega$	1.2 % of reading	Comparison to Decade Resistor
Resistance – Measure <sup>1</sup> Normal Mode	(10 to 100) $\mu\Omega$ (0.1 to 1) m $\Omega$ (1 to 10) m $\Omega$ (10 to 100) m $\Omega$ (0.1 to 1) $\Omega$ (1 to 10) $\Omega$ (10 to 100) $\Omega$ (0.01 to 1) k $\Omega$ (1 to 10) k $\Omega$ (10 to 100) k $\Omega$ (0.1 to 1) M $\Omega$ (1 to 10) M $\Omega$ (10 to 200) M $\Omega$ (0.2 to 2) G $\Omega$ (2 to 20) G $\Omega$	0.15 % of reading 15 $\mu\Omega/\Omega$ 5.1 $\mu\Omega/\Omega$ 1.8 $\mu\Omega/\Omega$ 0.92 $\mu\Omega/\Omega$ 0.74 $\mu\Omega/\Omega$ 1.7 $\mu\Omega/\Omega$ 1.3 $\mu\Omega/\Omega$ 2.4 $\mu\Omega/\Omega$ 1.1 $\mu\Omega/\Omega$ 8.2 $\mu\Omega/\Omega$ 21 $\mu\Omega/\Omega$ 72 $\mu\Omega/\Omega$ + 1k $\Omega$ 0.18 m $\Omega/\Omega$ + 100 k $\Omega$ 0.67 m $\Omega/\Omega$ + 10 M $\Omega$	Comparison to Decade Resistors with Bridge, DMM

**Electrical – DC/Low Frequency**

**Mundelein, IL**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Resistance – Measure <sup>1</sup> High Voltage Mode up to 200 V	(2 to 20) MΩ (20 to 200) MΩ 200 MΩ to 2 GΩ (2 to 20) GΩ	15 μΩ/Ω + 10 Ω 60 μΩ/Ω + 1 kΩ 0.15 mΩ/Ω + 100 kΩ 0.53 mΩ/Ω + 10 MΩ	Comparison to Decade Resistors with Bridge, DMM
Capacitance – Measure <sup>1</sup>	1 pF @ 1 kHz 10 pF @ 1 kHz 100 pF @ 1kHz 1 nF 1kHz 1 μF @ 1 kHz	1.9 mF/F 1.1 mF/F 1.2 mF/F 1.2 mF/F 1.2 mF/F	Comparison to QuadTech 1730 LCR Meter
Capacitance – Source <sup>1</sup> (Fixed Artifacts)	100 Hz, 1 kHz 1 pF 1 nF 10 nF 100 nF 1 μF	1.8 mF/F 0.23 mF/F 0.25 mF/F 0.21 mF/F 0.25 mF/F	Comparison to Standard Capacitors
Capacitance – Source <sup>1</sup> (Simulation) 10 Hz to 10 kHz 10 Hz to 3 kHz 10 Hz to 1 kHz 10 Hz to 1 kHz 10 Hz to 1 kHz (10 to 600) Hz 10 Hz to 300 Hz 10 Hz to 150 Hz 10 Hz to 120 Hz 10 Hz to 80 Hz (0 to 50) Hz (0 to 20) Hz (0 to 6) Hz (0 to 2) Hz (0 to 0.6) Hz (0 to 0.2) Hz	0.19 nF to 1.1 nF (1.1 to 3.3) nF (3.3 to 11) nF (11 to 110) nF (110 to 330) nF 330 nF to 1.1 μF (1.1 to 3.3) μF (3.3 to 11) μF (11 to 33) μF (33 to 110) μF (110 to 330) μF 330 μF to 1.1 mF (1.1 to 3.3) mF (3.3 to 11) mF (11 to 33) mF (33 to 110) mF	15 mF/F 8.4 mF/F 3.6 mF/F 3.6 mF/F 3.7 mF/F 3.6 mF/F 3.6 mF/F 3.6 mF/F 5.1 mF/F 5.6 mF/F 5.6 mF/F 8.7 mF/F 5.5 mF/F 5.5 mF/F 8.5 mF/F 12 mF/F	Comparison to Fluke 5520A Multi Product Calibrator
Inductance – Measure <sup>1</sup>	1 kHz 100 μH 1 mH 10 mH 100 mH 1 H	1.2 mH/H 1.2 mH/H 1.2 mH/H 1.2 mH/H 1.2 mH/H	Comparison to QuadTech 1730 LCR Meter

**Electrical – DC/Low Frequency**

**Mundelein, IL**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Inductance – Source <sup>1</sup> (Fixed Artifacts)	100 Hz		Comparison to Standard Inductors
	500 $\mu$ H	1.2 mH/H	
	2 mH	1.1 mH/H	
	20 mH	1.1 mH/H	
	1 H	1 mH/H	
	10 H	1 mH/H	
	1 kHz		
	500 $\mu$ H	1 mH/H	
	2 mH	1 mH/H	
	20 mH	1 mH/H	
	1 H	1 mH/H	
	10 H	1 mH/H	
Oscilloscopes <sup>1</sup>			Comparison to Fluke 9500B/3200/9530 Oscilloscope Calibrator
Square Wave Signal 50 $\Omega$ load	1 kHz		
	40 $\mu$ V to 5 V	1 mV/V	
Square Wave Signal 1 M $\Omega$ load	1 kHz		
	40 $\mu$ V to 5 V	1 mV/V	
DC Voltage Signal 50 $\Omega$ load	1 mV to 5 V	0.26 mV/V	
1 M $\Omega$ load	1 mV to 200 V	0.25 mV/V	
Leveled Sine Wave Amplitude	5 mV to 5 V	15 mV/V	
Leveled Sine Wave Flatness (relative to 50 kHz)	4.4 mVp-p to 5.6 Vp-p 0.1 Hz to 300 MHz (300 to 550) MHz	43 mV/V 43 mV/V	
	4.4 mVp-p to 3.3 Vp-p 550 MHz to 1.1 GHz (1.1 to 3.2) GHz	52 mV/V 52 mV/V	
Time Marker Source and Period (50 $\Omega$ load)	9 ns to 55 s	0.25 $\mu$ s/s	
Rise/Fall Time – Source	150 ps	27 ps	
Pulse Width – Source	(1 to 100) ns	52 ms/s	

**Electrical – DC/Low Frequency**

**Mundelein, IL**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Electrical Simulation of Thermocouple Indicators <sup>1</sup>	Type B		Comparison to Ectron 1140A Thermocouple Simulator
	(250 to 350) °C	1.1 °C	
	(350 to 445) °C	0.85 °C	
	(445 to 580) °C	0.67 °C	
	(580 to 750) °C	0.52 °C	
	(750 to 1 000) °C	0.43 °C	
	(1 000 to 1 820) °C	0.33 °C	
	Type C		
	(0 to 250) °C	0.23 °C	
	(250 to 1 000) °C	0.18 °C	
	(1 000 to 1 500) °C	0.21 °C	
	(1 500 to 1 800) °C	0.24 °C	
	(1 800 to 2 000) °C	0.27 °C	
	(2 000 to 2 250) °C	0.33 °C	
	(2 250 to 2 315) °C	0.37 °C	
	Type E		
	(-270 to -245) °C	1.4 °C	
	(-245 to -195) °C	0.21 °C	
	(-195 to -155) °C	0.12 °C	
	(-155 to -90) °C	0.09 °C	
	(-90 to 15) °C	0.08 °C	
	(15 to 890) °C	0.07 °C	
	(890 to 1 000) °C	0.08 °C	
	Type J		
	(-210 to -180) °C	0.14 °C	
	(-180 to -120) °C	0.12 °C	
	(-120 to -50) °C	0.09 °C	
	(-50 to 990) °C	0.08 °C	
	(990 to 1 200) °C	0.08 °C	
	Type K		
	(-270 to -255) °C	2.5 °C	
	(-255 to -195) °C	0.81 °C	
	(-195 to -115) °C	0.14 °C	
	(-115 to -55) °C	0.10 °C	
	(-55 to 1 000) °C	0.08 °C	
	(1 000 to 1 372) °C	0.09 °C	

**Electrical – DC/Low Frequency**

**Mundelein, IL**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Electrical Simulation of Thermocouple Indicators <sup>1</sup>	Type N		Comparison to Ectron 1140A Thermocouple Simulator
	(-270 to -260) °C	5.8 °C	
	(-260 to -200) °C	1.2 °C	
	(-200 to -140) °C	0.27 °C	
	(-140 to -70) °C	0.17 °C	
	(-70 to 25) °C	0.14 °C	
	(25 to 160) °C	0.12 °C	
	(160 to 1 300) °C	0.1 °C	
	Type R		
	(-50 to -30) °C	0.75 °C	
	(-30 to 45) °C	0.63 °C	
	(45 to 160) °C	0.46 °C	
	(160 to 380) °C	0.35 °C	
	(380 to 775) °C	0.3 °C	
	(775 to 1 768) °C	0.25 °C	
	Type S		
	(-50 to -30) °C	0.71 °C	
	(-30 to -45) °C	0.64 °C	
	(-45 to -105) °C	0.46 °C	
	(-105 to 310) °C	0.38 °C	
	(310 to 615) °C	0.33 °C	
	(615 to 1 768) °C	0.3 °C	
	Type T		
	(-270 to -255) °C	2.1 °C	
	(-255 to -240) °C	0.56 °C	
	(-240 to -210) °C	0.35 °C	
	(-210 to -150) °C	0.21 °C	
	(-150 to -40) °C	0.14 °C	
	(-40 to 100) °C	0.09 °C	
	(100 to 400) °C	0.08 °C	



**Electrical – DC/Low Frequency**

**Mundelein, IL**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Electrical Simulation of RTD Indicators <sup>1</sup>	PT 395 100 $\Omega$		Comparison to Fluke 5520A Multi Product Calibrator
	(-200 to 0) °C	0.06 °C	
	(0 to 100) °C	0.08 °C	
	(100 to 300) °C	0.11 °C	
	(300 to 400) °C	0.12 °C	
	(400 to 630) °C	0.14 °C	
	(630 to 800) °C	0.27 °C	
	PT 3926 100 $\Omega$		
	(-200 to 0) °C	0.06 °C	
	(0 to 100) °C	0.08 °C	
	(100 to 300) °C	0.11 °C	
	(300 to 400) °C	0.12 °C	
	(400 to 630) °C	0.14 °C	
	PT 3916 100 $\Omega$		
	(-200 to -190) °C	0.29 °C	
	(-190 to -80) °C	0.05 °C	
	(-80 to 0) °C	0.06 °C	
	(0 to 100) °C	0.07 °C	
	(100 to 260) °C	0.08 °C	
	(260 to 300) °C	0.09 °C	
	(300 to 400) °C	0.11 °C	
	(400 to 600) °C	0.12 °C	
	(600 to 630) °C	0.27 °C	
	PT 385 200 $\Omega$		
	(-200 to 100) °C	0.05 °C	
	(100 to 260) °C	0.06 °C	
	(260 to 300) °C	0.14 °C	
	(300 to 400) °C	0.15 °C	
	(400 to 600) °C	0.16 °C	
	(600 to 630) °C	0.19 °C	
	PT 385 500 $\Omega$		
	(-200 to -80) °C	0.05 °C	
	(-80 to 100) °C	0.06 °C	
	(100 to 260) °C	0.07 °C	
	(260 to 400) °C	0.09 °C	
	(400 to 600) °C	0.01 °C	
	(600 to 630) °C	0.13 °C	

**Electrical – DC/Low Frequency**

**Mundelein, IL**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Electrical Simulation of RTD Indicators <sup>1</sup>	PT 395 100 $\Omega$		Comparison to Fluke 5520A Multi Product Calibrator
	(-200 to 0) $^{\circ}\text{C}$	0.06 $^{\circ}\text{C}$	
	(0 to 100) $^{\circ}\text{C}$	0.08 $^{\circ}\text{C}$	
	(100 to 300) $^{\circ}\text{C}$	0.11 $^{\circ}\text{C}$	
	(300 to 400) $^{\circ}\text{C}$	0.12 $^{\circ}\text{C}$	
	(400 to 630) $^{\circ}\text{C}$	0.14 $^{\circ}\text{C}$	
	(630 to 800) $^{\circ}\text{C}$	0.27 $^{\circ}\text{C}$	
	PT 3926 100 $\Omega$		
	(-200 to 0) $^{\circ}\text{C}$	0.06 $^{\circ}\text{C}$	
	(0 to 100) $^{\circ}\text{C}$	0.08 $^{\circ}\text{C}$	
	(100 to 300) $^{\circ}\text{C}$	0.11 $^{\circ}\text{C}$	
	(300 to 400) $^{\circ}\text{C}$	0.12 $^{\circ}\text{C}$	
	(400 to 630) $^{\circ}\text{C}$	0.14 $^{\circ}\text{C}$	
	PT 3916 100 $\Omega$		
	(-200 to -190) $^{\circ}\text{C}$	0.29 $^{\circ}\text{C}$	
	(-190 to -80) $^{\circ}\text{C}$	0.05 $^{\circ}\text{C}$	
	(-80 to 0) $^{\circ}\text{C}$	0.06 $^{\circ}\text{C}$	
	(0 to 100) $^{\circ}\text{C}$	0.07 $^{\circ}\text{C}$	
	(100 to 260) $^{\circ}\text{C}$	0.08 $^{\circ}\text{C}$	
	(260 to 300) $^{\circ}\text{C}$	0.09 $^{\circ}\text{C}$	
	(300 to 400) $^{\circ}\text{C}$	0.11 $^{\circ}\text{C}$	
	(400 to 600) $^{\circ}\text{C}$	0.12 $^{\circ}\text{C}$	
	(600 to 630) $^{\circ}\text{C}$	0.27 $^{\circ}\text{C}$	
	PT 385 200 $\Omega$		
	(-200 to 100) $^{\circ}\text{C}$	0.05 $^{\circ}\text{C}$	
	(100 to 260) $^{\circ}\text{C}$	0.06 $^{\circ}\text{C}$	
	(260 to 300) $^{\circ}\text{C}$	0.14 $^{\circ}\text{C}$	
	(300 to 400) $^{\circ}\text{C}$	0.15 $^{\circ}\text{C}$	
	(400 to 600) $^{\circ}\text{C}$	0.16 $^{\circ}\text{C}$	
	(600 to 630) $^{\circ}\text{C}$	0.19 $^{\circ}\text{C}$	
	PT 385 500 $\Omega$		
	(-200 to -80) $^{\circ}\text{C}$	0.05 $^{\circ}\text{C}$	
	(-80 to 100) $^{\circ}\text{C}$	0.06 $^{\circ}\text{C}$	
	(100 to 260) $^{\circ}\text{C}$	0.07 $^{\circ}\text{C}$	
	(260 to 400) $^{\circ}\text{C}$	0.09 $^{\circ}\text{C}$	
	(400 to 600) $^{\circ}\text{C}$	0.01 $^{\circ}\text{C}$	
	(600 to 630) $^{\circ}\text{C}$	0.13 $^{\circ}\text{C}$	

## Electrical – DC/Low Frequency

Mundelein, IL

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Electrical Simulation of RTD Indicators <sup>1</sup>	PT 385 1 000 $\Omega$		Comparison to Fluke 5520A Multi Product Calibrator
	(-200 to 0) $^{\circ}\text{C}$	0.04 $^{\circ}\text{C}$	
	(0 to 100) $^{\circ}\text{C}$	0.05 $^{\circ}\text{C}$	
	(100 to 260) $^{\circ}\text{C}$	0.06 $^{\circ}\text{C}$	
	(260 to 300) $^{\circ}\text{C}$	0.07 $^{\circ}\text{C}$	
	(300 to 600) $^{\circ}\text{C}$	0.08 $^{\circ}\text{C}$	
	(600 to 630) $^{\circ}\text{C}$	0.27 $^{\circ}\text{C}$	
	PtNi 120 $\Omega$		
	(-80 to 100) $^{\circ}\text{C}$	0.09 $^{\circ}\text{C}$	
	(100 to 260) $^{\circ}\text{C}$	0.16 $^{\circ}\text{C}$	
	Cu 427 10 $\Omega$		
	(-100 to 260) $^{\circ}\text{C}$	0.35 $^{\circ}\text{C}$	

## Length – Dimensional Metrology

Mundelein, IL

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Gage Blocks <sup>2</sup>	(0.01 to 1) in (1 to 2) in 4 in	(1.4 + 1.3L) $\mu\text{in}$ (1 + 1.3L) $\mu\text{in}$ 9.4 $\mu\text{in}$	Comparison to Reference Gage Blocks, Gage Block Comparator
Gage Blocks <sup>2</sup>	100 mm (125 to 500) mm	0.17 $\mu\text{m}$ (0.06 + 0.000 6L) $\mu\text{m}$	Comparison to Primary Master Gage Blocks
Indicators <sup>1,2</sup>	(0.000 1 to 6) in	(5 + 8L) $\mu\text{in}$	Comparison to Horizontal Measuring Machine
Calipers <sup>1,2</sup>	Up to 60 in (60 to 80) in	(5 + 8L) $\mu\text{in}$ (410 + 2L) $\mu\text{in}$	Comparison to Gage Blocks
Outside Micrometers <sup>1,2</sup> Linearity	Up to 12 in (12 to 24) in	(5 + 8L) $\mu\text{in}$ (34 + 4.6L) $\mu\text{in}$	Comparison to Gage Blocks
Anvil Flatness	Up to 1 inD (0 to 84) $\mu\text{in}$	4 $\mu\text{in}$	Optical Parallels
Height Measuring Devices <sup>1,2</sup>	Up to 36 in (36 to 48) in	(45 + 2L) $\mu\text{in}$ (7 + 3L) $\mu\text{in}$	Comparison to Gage Blocks
Grind Gages	Up to 100 mm	0.35 mm	Comparison to Digital Indicator

**Length – Dimensional Metrology**

**Mundelein, IL**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Coating Thickness Gages <sup>1,2,7</sup>	Up to 0.02 in	58 $\mu$ in	Comparison to Coating Thickness Standards
Coating Thickness Gage Standards	Up to 0.1 in	21 $\mu$ in	Comparison to Horizontal Measuring Machine
External Diameter <sup>1,2</sup>	(0.000 1 to 12) in	(3 + 3L) $\mu$ in	Comparison to Horizontal Measuring Machine
Internal Diameter <sup>1,2</sup>	(0.04 to 13) in	(3 + 3L) $\mu$ in	Comparison to Horizontal Measuring Machine
Thread Rings (Adjustable) Pitch Diameter Tactile Fit (Set to Plug)	Up to 4 in	See footnote <sup>5</sup>	Comparison to Thread Setting Plug
Thread Plugs <sup>1,2</sup> Pitch Diameter	Up to 8 in Pitch (0.2 to 5) mm	(87 + 1.9L) $\mu$ in	Comparison to Horizontal Measuring Machine
Major Diameter	Pitch 90 – 4 TPI Up to 4 in	(3.5 + 4.6L) $\mu$ in	Thread Measuring Wires
Optical Comparators <sup>1,2</sup> Linear Accuracy	Up to 6 in 6 to 12 in	(43 + 11L) $\mu$ in (30 + 7.5L) $\mu$ in	Comparison to Glass Scale
Magnification	(5 to 100) X	350 $\mu$ in	Glass Scale (Sphere)
Surface Plates <sup>1,2</sup> Overall Flatness	Up to 238 inDL	(25 + 2.9L) $\mu$ in	Comparison to Laser System
Local Area Flatness	Up to 238 inDL	34 $\mu$ in	Repeat-O-Meter
Surface Finish Artifacts	Up to 500 $\mu$ in	2.4 $\mu$ in	Comparison to Profilometer, Master Patch
Profilometers <sup>1</sup>	Up to 500 $\mu$ in	3.1 $\mu$ in	Comparison to Master Patch
Optical Flats Parallelism	Up to 6 inD (0 to 80) $\mu$ in	2.7 $\mu$ in	Comparison to Gage Block Comparator,
Flatness	-	3.5 $\mu$ in	Master Flat

## Length – Dimensional Metrology

Mundelein, IL

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
CMMs <sup>1,2</sup>			
Linearity	Up to 144 in	$(25 + 2.4L) \mu\text{in}$	Comparison to Laser Measuring System
Volumetric Repeatability	(6 to 24) in (0.5 to 2) in	66 $\mu\text{in}$ 45 $\mu\text{in}$	Ball Bar, CMM Sphere
VMMs <sup>1,2</sup>			
X,Y Linearity	Up to 12 in	$(32 + 4.1L) \mu\text{in}$	Comparison to Glass Scales
Rulers and Pi Tapes	Up to 12 in	0.000 88 in	Comparison to Optical Slide w/ Indicator
Horizontal Measuring Systems <sup>1,2</sup>	Up to 8 in (8 to 60) in	$(6 + 1.7L) \mu\text{in}$ $(3 + 2.5L) \mu\text{in}$	Comparison to Gage Blocks
Protractors	(0 to 90)°	0.16°	Comparison to Sine Bar, Gage Blocks
Length Standards <sup>2</sup>	(1 to 60) in	$(3.4 + 3.5L) \mu\text{in}$	Comparison to Horizontal Measuring System
Inside Micrometers <sup>2</sup>	Up to 8 in (8 to 60) in	$(6 + 1.7L) \mu\text{in}$ $(3 + 2.5L) \mu\text{in}$	Comparison to Horizontal Measuring System

## Mass and Mass Related

Mundelein, IL

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Force <sup>1</sup> Source and Measure	(0.035 to 16) ozf (1 to 10) lbf (10 to 50) lbf (50 to 500) lbf	0.018 % of reading 0.018 % of reading 0.018 % of reading 0.036 % of reading	Comparison to Dead Weights
Force <sup>1</sup> Source and Measure	(500 to 1 000) lbf (1 000 to 10 000) lbf (10 000 to 100 000) lbf	0.05 % of reading 0.06 % of reading 0.06 % of reading	Comparison to Class AA Load Cells
Force <sup>1</sup> Source and Measure	(30 000 to 400 000) lbf	0.29 % of applied value	Comparison to Load Cells, Class A (compression only)
Pressure <sup>1</sup> (Absolute)	(10 to 17) psia	0.000 4 psi	Comparison to Pressure Calibrator
Pressure <sup>1</sup> (Gauge)	(-14.5 to -0.5) psig (1 to 16 000) psig	0.006 5 % of reading 0.006 5 % of reading	Comparison to Deadweight Tester

**Mass and Mass Related**

**Mundelein, IL**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Torque Tools <sup>1</sup>	0.5 ozf·in to 200 ozf·in (5 to 50) lbf·in (50 to 400) lbf·in (400 to 1000) lbf·in (80 to 250) lbf·ft (250 to 600) lbf·ft (600 to 1 000) lbf·ft	0.56 % of reading 0.33 % of reading 0.36 % of reading 0.4 % of reading 0.28 % of reading 0.51 % of reading 0.75 % of reading	Comparison to Torque Tester
Scales and Balances <sup>1,6</sup>	Up to 5 mg (5 to 500) mg 500 mg to 5 g (5 to 10) g (10 to 20) g (20 to 50) g (50 to 100) g (100 to 250) g 250 g to 1.1 kg (1.1 to 6.1) kg (6.1 to 33) kg	5 µg 6 µg 7 µg 12 µg 14 µg 24 µg 86 µg 92 µg 1.4 mg 9 mg 90 mg	Comparison to OIML Class E2, ASTM E617 Class 1 Weights, and internal calibration procedure utilized in the calibration of the weighing system.
Scales and Balances <sup>1,6</sup>	(0.5 to 2 000) lb	0.01 % of reading	Comparison to ASTM E617 Class 6 Weights, and internal calibration procedure utilized in the calibration of the weighing system.
Indirect Verification of Micro-indentation Hardness Testers <sup>1</sup> (Knoop and Vickers)	Repeatability under forces (gf): 100 ≤ HK ≤ 500 HV = 100	2.1 % of Reading 4.1 % of Reading	Indirect Verification to Hardness Test Blocks
Brinell Hardness Testers <sup>1</sup> Repeatability	500 kgf ≤ 100 HBW ≥ 64 HBW 1 500 kgf ≤ 257 HBW ≥ 91 HBW 3 000 kgf ≤ 587 HBW ≥ 186 HBW	0.025 mm 0.025 mm 0.025 mm 0.03 mm 0.025 mm 0.025 mm	Indirect Verification to Hardness Test Blocks

**Mass and Mass Related**

**Mundelein, IL**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Rockwell Hardness Testers <sup>1</sup>	HRA Low	0.69 HRA	Indirect Verification to Hardness Test Blocks
	HRA Middle	0.62 HRA	
	HRA High	0.362 HRA	
	HRBW Low	0.71 HRBW	
	HRBW Middle	0.53 HRBW	
	HRBW High	0.9 HRBW	
	HRC Low	0.54 HRC	
	HRC Middle	0.7 HRC	
	HRC High	0.38 HRC	
Rockwell Hardness Testers <sup>1</sup>	HREW Low	0.49 HREW	Indirect Verification to Hardness Test Blocks
	HREW Middle	0.39 HREW	
	HREW High	0.88 HREW	
	HRMW Low	0.65 HRMW	
	HRMW Middle	0.55 HRMW	
	HRMW High	0.65 HRMW	
	HR15N Low	0.69 HR15N	
	HR15N Middle	0.69 HR15N	
	HR15N High	0.36 HR15N	
	HR15TW Low	0.87 HR15TW	
	HR15TW Middle	0.72 HR15TW	
	HR15TW High	0.72 HR15TW	
	HR30N Low	0.87 HR30N	
	HR30N Middle	0.91 HR30N	
	HR30N High	0.36 HR30N	
	HR30TW Low	0.54 HR30TW	
	HR30TW Middle	0.72 HR30TW	
	HR30TW High	0.39 HR30TW	
	HR45N Low	0.64 HR45N	
	HR45N Middle	1.2 HR45N	
	HR45N High	0.34 HR45N	
Rockwell Hardness Testers <sup>1</sup>	HR45TW Low	0.92 HR45TW	Indirect Verification to Hardness Test Blocks
	HR45TW Middle	0.92 HR45TW	
	HR45TW High	0.61 HR45TW	



## Mass and Mass Related

Mundelein, IL

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Durometers			
Spring Force			
Types A, B, E, O	(1.3 to 8.05) N	0.023 N	Full Verification using Shore Durometer Calibrator, Balance
Types C, D, and DO	(4.445 to 44.5) N	0.06 N	
Types OO, OOO, OOO-S	(0.294 to 1.932) N	0.002 N	
Indenter Dimensions			Video Measuring Machine
Angle	(20 to 40)°	0.05°	
Length	(0.049 to 0.198) in	220 µin	
Radius	(0.05 to 0.1) in	250 µin	

## Thermodynamic

Mundelein, IL

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Temperature - Measure	(-200 to -20) °C (-20 to 120) °C (120 to 200) °C (200 to 300) °C (300 to 600) °C	0.006 2 °C 0.001 7 °C 0.023 °C 0.023 °C 0.024 °C	Comparison to Fluke 5699 SPRT, Fluke 1590 Super Thermometer
Temperature – Source	(-20 to 120) °C (120 to 425) °C (425 to 660) °C	0.001 7 °C 0.038 °C 0.063 °C	Comparison to SPRT, Fluke 1590 Super Thermometer Liquid Baths, Metrology Well
Radiation (Infrared) Thermometers	(50 to 100) °C (100 to 200) °C (200 to 250) °C (250 to 300) °C (300 to 400) °C (400 to 500) °C	0.8 °C 0.93 °C 0.96 °C 1 °C 1.1 °C 1.2 °C	Comparison to Black Body Calibrator monitored with a PRT (flat plate) $\epsilon = 0.95$ , $\lambda = (8 \text{ to } 14) \mu\text{m}$
Humidity Measure <sup>1</sup>	(10 to 90) %RH (95 to 98) %RH	1.1 %RH 2 %RH	Comparison to Humidity Indicator
Temperature Uniformity Survey <sup>1</sup> (TUS)	Up to 200 °F (200 to 1 000) °F (1 000 to 1 400) °F (1 400 to 1 800) °F (1 800 to 2 000) °F (2 000 to 2 300) °F	1.6 °F 1.8 °F 2.1 °F 2.9 °F 4.1 °F 4.3 °F	Comparison to Temperature Datalogger, Type K Thermocouples per AMS 2750.

## DIMENSIONAL MEASUREMENT

### 2 Dimensional

Mundelein, IL

Specific Tests and / or Properties Measured	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method and/or Equipment
2-D Non-contact <sup>2</sup>	(6 x 8) in	(239 + 1.4L) $\mu$ in	Comparison to Vision System
Surface Finish Analysis	Up to 500 $\mu$ in	2.4 $\mu$ in	Comparison to Profilometer, Master Patch

### 3 Dimensional

Mundelein, IL

Specific Tests and / or Properties Measured	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method and/or Equipment
Dimensional Inspection Contact <sup>2</sup>	(16 x 18 x 14) in	(209 + 1.2L) $\mu$ in	Comparison to Coordinate Measuring Machine

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### Services performed at satellite laboratory

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### CALIBRATION

#### Electrical – DC/Low Frequency

Eau Claire, WI

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
DC Voltage – Source <sup>1</sup>	Up to 330 mV 330 mV to 3.3 V (3.3 to 33) V (33 to 330) V (330 to 1 020) V	21 $\mu\text{V/V} + 1 \mu\text{V}$ 11 $\mu\text{V/V} + 2 \mu\text{V}$ 13 $\mu\text{V/V} + 20 \mu\text{V}$ 18 $\mu\text{V/V} + 150 \mu\text{V}$ 18 $\mu\text{V/V} + 1.5 \text{ mV}$	Comparison to Fluke 5522A Multi Product Calibrator
DC Voltage – Measure <sup>1</sup>	Up to 100 mV 100 mV to 1 V (1 to 10) V (10 to 100) V 100 V to 1 kV	12 $\mu\text{V/V} + 0.3 \mu\text{V}$ 10 $\mu\text{V/V} + 0.3 \mu\text{V}$ 10 $\mu\text{V/V} + 0.5 \mu\text{V}$ 13 $\mu\text{V/V} + 30 \mu\text{V}$ 13 $\mu\text{V/V} + 100 \mu\text{V}$	Comparison to Keysight 3458A 8.5 Digit Multimeter
DC Current – Source <sup>1</sup>	Up to 330 $\mu\text{A}$ 330 $\mu\text{A}$ to 3.3 mA (3.3 to 33) mA (33 to 330) mA 330 mA to 1.1 A (1.1 to 3) A (3 to 11) A (11 to 20) A	151 $\mu\text{A/A} + 20 \text{ nA}$ 101 $\mu\text{A/A} + 50 \text{ nA}$ 101 $\mu\text{A/A} + 250 \text{ nA}$ 102 $\mu\text{A/A} + 2.5 \mu\text{A}$ 201 $\mu\text{A/A} + 40 \mu\text{A}$ 386 $\mu\text{A/A} + 40 \mu\text{A}$ 504 $\mu\text{A/A} + 0.5 \text{ mA}$ 1 mA/A + 0.75 mA	Comparison to Fluke 5522A Multi Product Calibrator
DC Current – Measure <sup>1</sup>	(10 to 100) $\mu\text{A}$ 100 $\mu\text{A}$ to 1 mA (1 to 10) mA (10 to 100) mA 100 mA to 1 A	29 $\mu\text{A/A} + 0.8 \text{ nA}$ 27 $\mu\text{A/A} + 5 \text{ nA}$ 28 $\mu\text{A/A} + 50 \text{ nA}$ 46 $\mu\text{A/A} + 0.5 \mu\text{A}$ 121 $\mu\text{A/A} + 10 \mu\text{A}$	Comparison to Keysight 3458A 8.5 Digit Multimeter

**Electrical – DC/Low Frequency**

**Eau Claire, WI**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Voltage – Source	Up to 33 mV (10 to 45) Hz	806 $\mu\text{V/V} + 6 \mu\text{V}$	Comparison to Fluke 5522A Multi Product Calibrator
	45 Hz to 10 kHz (10 to 20) kHz	176 $\mu\text{V/V} + 6 \mu\text{V}$	
	(20 to 50) kHz	220 $\mu\text{V/V} + 6 \mu\text{V}$	
	(50 to 100) kHz	1 mV/V + 6 $\mu\text{V}$	
	(100 to 500) kHz	3.5 mV/V + 12 $\mu\text{V}$	
	(33 to 330) mV (10 to 45) Hz	8 mV/V + 50 $\mu\text{V}$	
	45 Hz to 10 kHz (10 to 20) kHz	302 $\mu\text{V/V} + 8 \mu\text{V}$	
	(20 to 50) kHz	148 $\mu\text{V/V} + 8 \mu\text{V}$	
	(50 to 100) kHz	163 $\mu\text{V/V} + 8 \mu\text{V}$	
	(100 to 500) kHz	353 $\mu\text{V/V} + 8 \mu\text{V}$	
	330 mV to 3.3 V (10 to 45) Hz	804 $\mu\text{V/V} + 32 \mu\text{V}$	
	45 Hz to 10 kHz (10 to 20) kHz	2 mV/V + 70 $\mu\text{V}$	
	(20 to 50) kHz	302 $\mu\text{V/V} + 50 \mu\text{V}$	
	(50 to 100) kHz	153 $\mu\text{V/V} + 60 \mu\text{V}$	
	(100 to 500) kHz	192 $\mu\text{V/V} + 60 \mu\text{V}$	
	(3.3 to 33) V (10 to 45) Hz	302 $\mu\text{V/V} + 50 \mu\text{V}$	
	45 Hz to 10 kHz (10 to 20) kHz	703 $\mu\text{V/V} + 125 \mu\text{V}$	
	(20 to 50) kHz	2.4 mV/V + 0.6 mV	
	(50 to 100) kHz	302 $\mu\text{V/V} + 650 \mu\text{V}$	
	(33 to 330) V (10 to 45) Hz	153 $\mu\text{V/V} + 600 \mu\text{V}$	
	45 Hz to 1 kHz (1 to 10) kHz	242 $\mu\text{V/V} + 600 \mu\text{V}$	
	(10 to 20) kHz	353 $\mu\text{V/V} + 600 \mu\text{V}$	
	(20 to 50) kHz	903 $\mu\text{V/V} + 1.6 \text{ mV}$	
	(50 to 100) kHz	194 $\mu\text{V/V} + 2 \text{ mV}$	
	(330 to 1020) V (1 to 5) kHz	204 $\mu\text{V/V} + 6 \text{ mV}$	
	(5 to 10) kHz	253 $\mu\text{V/V} + 6 \text{ mV}$	
		314 $\mu\text{V/V} + 6 \text{ mV}$	
		2 mV/V + 50 mV	
		302 $\mu\text{V/V} + 10 \text{ mV}$	
		252 $\mu\text{V/V} + 10 \text{ mV}$	
		302 $\mu\text{V/V} + 10 \text{ mV}$	

**Electrical – DC/Low Frequency**

**Eau Claire, WI**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Voltage – Measure	Up to 10 mV		Comparison to Keysight 3458A 8.5 Digit Multimeter
	(1 to 40) Hz	300 $\mu\text{V/V} + 3 \mu\text{V}$	
	40 Hz to 1 kHz	219 $\mu\text{V/V} + 1.1 \mu\text{V}$	
	(1 to 20) kHz	324 $\mu\text{V/V} + 1.1 \mu\text{V}$	
	(20 to 50) kHz	1 mV/V + 6 $\mu\text{V}$	
	(50 to 100) kHz	5.1 mV/V + 1.1 $\mu\text{V}$	
	(100 to 300) kHz	41 mV/V + 2 $\mu\text{V}$	
	(10 to 100) mV		
	(1 to 40) Hz	70 $\mu\text{V/V} + 4 \mu\text{V}$	
	40 Hz to 1 kHz	83.8 $\mu\text{V/V} + 2 \mu\text{V}$	
	(1 to 20) kHz	157 $\mu\text{V/V} + 2 \mu\text{V}$	
	(20 to 50) kHz	308 $\mu\text{V/V} + 2 \mu\text{V}$	
	(50 to 100) kHz	878 $\mu\text{V/V} + 2 \mu\text{V}$	
	(100 to 300) kHz	3.1 mV/V + 10 $\mu\text{V}$	
	300 kHz to 1 MHz	10 mV/V + 10 $\mu\text{V}$	
	(1 to 2) MHz	15 mV/V + 10 $\mu\text{V}$	
	100 mV to 1 V		
	(1 to 40) Hz	70 $\mu\text{V/V} + 40 \mu\text{V}$	
	40 Hz to 1 kHz	80.7 $\mu\text{V/V} + 20 \mu\text{V}$	
	(1 to 20) kHz	154 $\mu\text{V/V} + 20 \mu\text{V}$	
	(20 to 50) kHz	327 $\mu\text{V/V} + 20 \mu\text{V}$	
	(50 to 100) kHz	825 $\mu\text{V/V} + 20 \mu\text{V}$	
	(100 to 300) kHz	3.1 mV/V + 0.1 mV	
	300 kHz to 1 MHz	10 mV/V + 0.1 mV	
	(1 to 2) MHz	15 mV/V + 0.1 mV	
	(1 to 10) V		
	(1 to 40) Hz	77 $\mu\text{V/V} + 400 \mu\text{V}$	
	40 Hz to 1 kHz	81 $\mu\text{V/V} + 200 \mu\text{V}$	
	(1 to 20) kHz	154 $\mu\text{V/V} + 200 \mu\text{V}$	
	(20 to 50) kHz	324 $\mu\text{V/V} + 200 \mu\text{V}$	
	(50 to 100) kHz	816 $\mu\text{V/V} + 200 \mu\text{V}$	
	(100 to 300) kHz	3.1 mV/V + 1 mV	
	300 kHz to 1 MHz	10 mV/V + 1 mV	
	(1 to 2) MHz	15 mV/V + 1 mV	

**Electrical – DC/Low Frequency**

**Eau Claire, WI**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Voltage – Measure	(10 to 100) V		Comparison to Keysight 3458A 8.5 Digit Multimeter
	(1 to 40) Hz	200 $\mu\text{V/V} + 4 \text{ mV}$	
	40 Hz to 1 kHz	205 $\mu\text{V/V} + 2 \text{ mV}$	
	(1 to 20) kHz	215 $\mu\text{V/V} + 2 \text{ mV}$	
	(20 to 50) kHz	358 $\mu\text{V/V} + 2 \text{ mV}$	
	(50 to 100) kHz	1.2 $\text{mV/V} + 2 \text{ mV}$	
	(100 to 300) kHz	4 $\text{mV/V} + 2 \text{ mV}$	
	300 kHz to 1 MHz	15 $\text{mV/V} + 10 \text{ mV}$	
	(100 to 1 000) V		
	(1 to 40) Hz	400 $\mu\text{V/V} + 40 \text{ mV}$	
	40 Hz to 1 kHz	405 $\mu\text{V/V} + 20 \text{ mV}$	
	(1 to 20) kHz	600 $\mu\text{V/V} + 20 \text{ mV}$	
	(20 to 50) kHz	1.2 $\text{mV/V} + 20 \text{ mV}$	
	(50 to 100) kHz	3 $\text{mV/V} + 20 \text{ mV}$	
AC Current – Measure	Up to 100 $\mu\text{A}$		Comparison to Keysight 3458A 8.5 Digit Multimeter
	(10 to 20) Hz	4 $\text{mA/A} + 30 \text{ nA}$	
	(20 to 45) Hz	1.5 $\text{mA/A} + 30 \text{ nA}$	
	(45 to 100) Hz	605 $\mu\text{A/A} + 30 \text{ nA}$	
	100 Hz to 1 kHz	610 $\mu\text{A/A} + 30 \text{ nA}$	
	100 $\mu\text{A}$ to 1 mA		
	(10 to 20) Hz	4 $\text{mA/A} + 0.2 \mu\text{A}$	
	(20 to 45) Hz	1.5 $\text{mA/A} + 0.2 \mu\text{A}$	
	(45 to 100) Hz	605 $\mu\text{A/A} + 0.2 \mu\text{A}$	
	100 Hz to 5 kHz	325 $\mu\text{A/A} + 0.2 \mu\text{A}$	
	(5 to 20) kHz	605 $\mu\text{A/A} + 0.2 \mu\text{A}$	
	(20 to 50) kHz	4 $\text{mA/A} + 0.4 \mu\text{A}$	
	(50 to 100) kHz	5.5 $\text{mA/A} + 1.5 \mu\text{A}$	
	(1 to 10) mA		
	(10 to 20) Hz	4 $\text{mA/A} + 2 \mu\text{A}$	
	(20 to 45) Hz	1.5 $\text{mA/A} + 2 \mu\text{A}$	
	(45 to 100) Hz	605 $\mu\text{A/A} + 2 \mu\text{A}$	
	100 Hz to 5 kHz	325 $\mu\text{A/A} + 2 \mu\text{A}$	
	(5 to 20) kHz	605 $\mu\text{A/A} + 2 \mu\text{A}$	
	(20 to 50) kHz	4 $\text{mA/A} + 4 \mu\text{A}$	
	(50 to 100) kHz	5.5 $\text{mA/A} + 15 \mu\text{A}$	

**Electrical – DC/Low Frequency**

**Eau Claire, WI**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Current – Measure	(10 to 100) mA		Comparison to Keysight 3458A 8.5 Digit Multimeter
	(10 to 20) Hz	4 mA/A + 20 $\mu$ A	
	(20 to 45) Hz	1.5 mA/A + 20 $\mu$ A	
	(45 to 100) Hz	605 $\mu$ A/A + 20 $\mu$ A	
	100 Hz to 5 kHz	325 $\mu$ A/A + 20 $\mu$ A	
	(5 to 20) kHz	605 $\mu$ A/A + 20 $\mu$ A	
	(20 to 50) kHz	4 mA/A + 40 $\mu$ A	
	(50 to 100) kHz	5.5 mA/A + 150 $\mu$ A	
	100 mA to 1 A		
	(10 to 20) Hz	4 mA/A + 0.2 mA	
	(20 to 45) Hz	1.6 mA/A + 0.2 mA	
	(45 to 100) Hz	805 $\mu$ A/A + 0.2 mA	
	100 Hz to 5 kHz	1 mA/A + 0.2 mA	
	(5 to 20) kHz	3 mA/A + 0.2 mA	
	(20 to 50) kHz	10 mA/A + 0.4 mA	
AC Current – Source	(29 to 330) $\mu$ A		Comparison to Fluke 5522A Multi Product Calibrator
	(10 to 20) Hz	2 mA/A + 0.1 $\mu$ A	
	(20 to 45) Hz	1.5 mA/A + 0.1 $\mu$ A	
	45 Hz to 1 kHz	1.3 mA/A + 0.1 $\mu$ A	
	(1 to 5) kHz	3 mA/A + 0.15 $\mu$ A	
	(5 to 10) kHz	8 mA/A + 0.2 $\mu$ A	
	(10 to 30) kHz	16 mA/A + 0.4 $\mu$ A	
	(0.33 to 3.3) mA		
	(10 to 20) Hz	2 mA/A + 0.15 $\mu$ A	
	(20 to 45) Hz	1.3 mA/A + 0.15 $\mu$ A	
	45 Hz to 1 kHz	1 mA/A + 0.15 $\mu$ A	
	(1 to 5) kHz	2 mA/A + 0.2 $\mu$ A	
	(5 to 10) kHz	5.1 mA/A + 0.3 $\mu$ A	
	(10 to 30) kHz	10 mA/A + 0.6 $\mu$ A	
	(3.3 to 33) mA		
	(10 to 20) Hz	1.8 mA/A + 2 $\mu$ A	
	(20 to 45) Hz	910 $\mu$ A/A + 2 $\mu$ A	
	45 Hz to 1 kHz	423 $\mu$ A/A + 2 $\mu$ A	
	(1 to 5) kHz	813 $\mu$ A/A + 2 $\mu$ A	
	(5 to 10) kHz	2 mA/A + 3 $\mu$ A	
	(10 to 30) kHz	4.1 mA/A + 4 $\mu$ A	



**Electrical – DC/Low Frequency**

**Eau Claire, WI**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
AC Current – Source	(33 to 330) mA		Comparison to Fluke 5522A Multi Product Calibrator
	(10 to 20) Hz	1.8 mA/A + 20 $\mu$ A	
	(20 to 45) Hz	909 $\mu$ A/A + 20 $\mu$ A	
	45 Hz to 1 kHz	417 $\mu$ A/A + 20 $\mu$ A	
	(1 to 5) kHz	1 mA/A + 50 $\mu$ A	
	(5 to 10) kHz	2 mA/A + 100 $\mu$ A	
	(10 to 30) kHz	4.1 mA/A + 200 $\mu$ A	
	(0.33 to 1.1) A		
	(10 to 45) Hz	1.8 mA/A + 100 $\mu$ A	
	45 Hz to 1 kHz	512 $\mu$ A/A + 100 $\mu$ A	
	(1 to 5) kHz	6 mA/A + 1 mA	
	(5 to 10) kHz	25 mA/A + 5 mA	
	(1.1 to 3) A		
	(10 to 45) Hz	1.8 mA/A + 100 $\mu$ A	
	45 Hz to 1 kHz	664 $\mu$ A/A + 100 $\mu$ A	
	(1 to 5) kHz	6 mA/A + 1 mA	
	(5 to 10) kHz	25 mA/A + 5 mA	
	(3 to 11) A		
	(45 to 100) Hz	1.8 mA/A + 100 $\mu$ A	
	100 Hz to 1 kHz	664 $\mu$ A/A + 100 $\mu$ A	
	(1 to 5) kHz	6 mA/A + 1 mA	
Resistance – Measure <sup>1</sup>	(11 to 20.5) A		Comparison to Keysight 3458A 8.5 Digit Multimeter
	(45 to 100) Hz	1.2 mA/A + 5 mA	
	100 Hz to 1 kHz	1.5 mA/A + 5 mA	
	(1 to 5) kHz	30 mA/A + 5 mA	
	100 $\mu\Omega$ to 10 $\Omega$	20 $\mu\Omega/\Omega$ + 50 $\mu\Omega$	
	(10 to 100) $\Omega$	17 $\mu\Omega/\Omega$ + 5 $\mu\Omega$	
	100 $\Omega$ to 1 k $\Omega$	15 $\mu\Omega/\Omega$ + 500 $\mu\Omega$	
	(1 to 10) k $\Omega$	15 $\mu\Omega/\Omega$ + 5 m $\Omega$	
	(10 to 100) k $\Omega$	15 $\mu\Omega/\Omega$ + 50 m $\Omega$	
	100 k $\Omega$ to 1 M $\Omega$	20 $\mu\Omega/\Omega$ + 2 $\Omega$	
	(1 to 10) M $\Omega$	83 $\mu\Omega/\Omega$ + 100 $\Omega$	
	(10 to 100) M $\Omega$	820 $\mu\Omega/\Omega$ + 1 k $\Omega$	

**Electrical – DC/Low Frequency**

**Eau Claire, WI**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Resistance – Source <sup>1</sup> (Simulation)	Up to 11 $\Omega$	36 $\mu\Omega/\Omega$	Comparison to Fluke 5522A Multi Product Calibrator
	(11 to 33) $\Omega$	26 $\mu\Omega/\Omega$	
	(33 to 110) $\Omega$	23 $\mu\Omega/\Omega$	
	(110 to 330) $\Omega$	23 $\mu\Omega/\Omega$	
	330 $\Omega$ to 1.1 k $\Omega$	23 $\mu\Omega/\Omega$	
	(1.1 to 3.3) k $\Omega$	23 $\mu\Omega/\Omega$	
	(3.3 to 11) k $\Omega$	23 $\mu\Omega/\Omega$	
	(11 to 33) k $\Omega$	23 $\mu\Omega/\Omega$	
	(33 to 110) k $\Omega$	24 $\mu\Omega/\Omega$	
	(110 to 330) k $\Omega$	26 $\mu\Omega/\Omega$	
	330 k $\Omega$ to 1.1 M $\Omega$	26 $\mu\Omega/\Omega$	
	(1.1 to 3.3) M $\Omega$	42 $\mu\Omega/\Omega$	
	(3.3 to 11) M $\Omega$	110 $\mu\Omega/\Omega$	
	(11 to 33) M $\Omega$	201 $\mu\Omega/\Omega$	
	(33 to 110) M $\Omega$	400 $\mu\Omega/\Omega$	
Capacitance – Source <sup>1</sup> (Simulation)	(110 to 330) M $\Omega$	2.5 m $\Omega/\Omega$	Comparison to Fluke 5522A Multi Product Calibrator
	330 M $\Omega$ to 1.1 G $\Omega$	12 m $\Omega/\Omega$	
	10 Hz to 10 kHz		
	(220 to 400) pF	6.4 mF/F + 10 pF	
	(0.4 to 1.1) nF	5.3 mF/F + 10 pF	
	10 Hz to 3 kHz		
	(1.1 to 3.3) nF	5.1 mF/F + 10 pF	
	10 Hz to 1 kHz		
	(3.3 to 11) nF	2.6 mF/F + 10 pF	
	(11 to 33) nF	2.6 mF/F + 100 pF	
	(33 to 110) nF	2.6 mF/F + 100 pF	
	(110 to 330) nF	2.6 mF/F + 300 pF	
	(10 to 600) Hz		
	(0.33 to 1.1) $\mu$ F	2.6 mF/F + 1 nF	
	(10 to 300) Hz		
	(1.1 to 3.3) $\mu$ F	2.6 mF/F + 3 nF	
	(10 to 150) Hz		
	(3.3 to 11) $\mu$ F	2.6 mF/F + 10 nF	
	(10 to 120) Hz		
	(11 to 33) $\mu$ F	4.1 mF/F + 30 nF	
	(10 to 80) Hz		
	(33 to 110) $\mu$ F	4.7 mF/F + 0.1 $\mu$ F	
	DC to 50 Hz		
	(110 to 330) $\mu$ F	4.6 mF/F + 0.3 $\mu$ F	

**Electrical – DC/Low Frequency**

**Eau Claire, WI**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Capacitance – Source <sup>1</sup> (Simulation)	DC to 20 Hz (0.33 to 1.1) mF DC to 6 Hz (1.1 to 3.3) mF DC to 2 Hz (3.3 to 11) mF DC to 0.6 Hz (11 to 33) mF DC to 0.2 Hz (33 to 110) mF	4.6 mF/F + 1 $\mu$ F 4.5 mF/F + 3 $\mu$ F 4.5 mF/F + 10 $\mu$ F 7.5 mF/F + 30 $\mu$ F 11 mF/F + 100 $\mu$ F	Comparison to Fluke 5522A Multi Product Calibrator
Electrical Simulation of Thermocouple Indicators <sup>1</sup>	Type B (600 to 800) °C (800 to 1 000) °C (1 000 to 1 550) °C (1 550 to 1 820) °C Type C (0 to 150) °C (150 to 650) °C (650 to 1 000) °C (1 000 to 1 800) °C (1 800 to 2 316) °C Type E (-250 to -100) °C (-100 to -25) °C (-25 to 350) °C (350 to 650) °C (650 to 1 000) °C Type J (-210 to -100) °C (-100 to - 30) °C (-30 to 150) °C (150 to 760) °C (760 to 1 200) °C Type K (-200 to -100) °C (-100 to -25) °C (-25 to 120) °C (120 to 1 000) °C (1 000 to 1 372) °C	0.44 °C 0.34 °C 0.3 °C 0.33 °C 0.3 °C 0.26 °C 0.31 °C 0.5 °C 0.84 °C 0.5 °C 0.16 °C 0.14 °C 0.16 °C 0.21 °C 0.27 °C 0.16 °C 0.14 °C 0.17 °C 0.23 °C 0.33 °C 0.18 °C 0.16 °C 0.26 °C 0.4 °C	Comparison to Fluke 5522A Multi Product Calibrator

**Electrical – DC/Low Frequency**

**Eau Claire, WI**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Electrical Simulation of Thermocouple Indicators <sup>1</sup>	Type L		Comparison to Fluke 5522A Multi Product Calibrator
	(-200 to -100) °C	0.37 °C	
	(-100 to 800) °C	0.26 °C	
	(800 to 900) °C	0.17 °C	
	Type N		
	(-200 to -100) °C	0.4 °C	
	(-100 to - 25) °C	0.22 °C	
	(-25 to 120) °C	0.19 °C	
	(120 to 410) °C	0.18 °C	
	(410 to 1 300) °C	0.27 °C	
	Type R		
	(0 to 250) °C	0.57 °C	
	(250 to 400) °C	0.35 °C	
	(400 to 1 000) °C	0.33 °C	
	(1 000 to 1 767) °C	0.4 °C	
	Type S		
	(0 to 250) °C	0.47 °C	
	(250 to 400) °C	0.36 °C	
	(400 to 1 000) °C	0.37 °C	
	(1 000 to 1 767) °C	0.46 °C	
	Type T		
	(-250 to -150) °C	0.63 °C	
	(-150 to 0) °C	0.24 °C	
	(0 to 120) °C	0.16 °C	
	(120 to 400) °C	0.14 °C	
	Type U		
	(-200 to 0) °C	0.56 °C	
	(0 to 600) °C	0.27 °C	
Electrical Simulation of RTD Indicators <sup>1</sup>	Pt 385, 100 Ω		Comparison to Fluke 5522A Multi Product Calibrator
	(-200 to -80) °C	0.05 °C	
	(-80 to 0) °C	0.05 °C	
	(0 to 100) °C	0.07 °C	
	(100 to 300) °C	0.09 °C	
	(300 to 400) °C	0.1 °C	
	(400 to 630) °C	0.12 °C	
	(630 to 800) °C	0.23 °C	

**Electrical – DC/Low Frequency**

**Eau Claire, WI**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Electrical Simulation of RTD Indicators <sup>1</sup>	Pt 3926, 100 $\Omega$		Comparison to Fluke 5522A Multi Product Calibrator
	(-200 to -80) °C	0.05 °C	
	(-80 to 0) °C	0.05 °C	
	(0 to 100) °C	0.07 °C	
	(100 to 300) °C	0.09 °C	
	(300 to 400) °C	0.10 °C	
	(400 to 630) °C	0.12 °C	
	Pt 3916, 100 $\Omega$		
	(-200 to -190) °C	0.25 °C	
	(-190 to -80) °C	0.04 °C	
	(-80 to 0) °C	0.05 °C	
	(0 to 100) °C	0.06 °C	
	(100 to 260) °C	0.07 °C	
	(260 to 300) °C	0.08 °C	
	(300 to 400) °C	0.09 °C	
	(400 to 600) °C	0.1 °C	
	(600 to 630) °C	0.23 °C	
	Pt 385, 200 $\Omega$		
	(-200 to -80) °C	0.04 °C	
	(-80 to 0) °C	0.04 °C	
	(0 to 100) °C	0.04 °C	
	(100 to 260) °C	0.05 °C	
	(260 to 300) °C	0.12 °C	
	(300 to 400) °C	0.13 °C	
	(400 to 600) °C	0.14 °C	
	(600 to 630) °C	0.16 °C	
	Pt 385, 500 $\Omega$		
	(-200 to -80) °C	0.04 °C	
	(-80 to 0) °C	0.05 °C	
	(0 to 100) °C	0.05 °C	
	(100 to 260) °C	0.06 °C	
	(260 to 300) °C	0.08 °C	
	(300 to 400) °C	0.08 °C	
	(400 to 600) °C	0.09 °C	
	(600 to 630) °C	0.11 °C	

## Electrical – DC/Low Frequency

Eau Claire, WI

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Electrical Simulation of RTD Indicators <sup>1</sup>	Pt 385, 1 000 $\Omega$		Comparison to Fluke 5522A Multi Product Calibrator
	(-200 to -80) °C	0.03 °C	
	(-80 to 0) °C	0.03 °C	
	(0 to 100) °C	0.04 °C	
	(100 to 260) °C	0.05 °C	
	(260 to 300) °C	0.06 °C	
	(300 to 400) °C	0.07 °C	
	(400 to 600) °C	0.07 °C	
	(600 to 630) °C	0.23 °C	
	PtNi 385, 120 $\Omega$ (Ni120)		
	(-80 to 0) °C	0.08 °C	
	(0 to 100) °C	0.08 °C	
	(100 to 260) °C	0.14 °C	
	Cu 427, 10 $\Omega$		
	(100 to 260) °C	0.3 °C	

## Length – Dimensional Metrology

Eau Claire, WI

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Indicators <sup>1,2</sup>	(0.000 1 to 6) in	(8 + 3L) $\mu$ in	Comparison to Horizontal Measuring Machine
Calipers <sup>1,2</sup>	Up to 60 in (60 to 80) in	(5 + 8L) $\mu$ in (410 + 2L) $\mu$ in	Comparison to Gage Blocks
Outside Micrometers <sup>1,2</sup> Linearity	Up to 12 in (12 to 24) in	(5 + 8L) $\mu$ in (34 + 4.6L) $\mu$ in	Comparison to Gage Blocks
Anvil Flatness	Up to 1 inD (0 to 84) $\mu$ in	4 $\mu$ in	Optical Parallels
Height Measuring Devices <sup>1,2</sup>	Up to 36 in (36 to 48) in	(45 + 2L) $\mu$ in (7 + 3L) $\mu$ in	Comparison to Gage Blocks
External Diameter <sup>1,2</sup>	(0.000 1 to 6) in	(8+3L) $\mu$ in	Comparison to Horizontal Measuring Machine
Internal Diameter <sup>1,2</sup>	(0.04 to 13) in	(8+3L) $\mu$ in	Comparison to Horizontal Measuring Machine

**Length – Dimensional Metrology**

**Eau Claire, WI**

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Thread Plugs <sup>1,2</sup> Pitch Diameter	Up to 8 in Pitch (0.2 to 5) mm	$(87 + 1.9L) \mu\text{in}$	Comparison to Horizontal Measuring Machine
Major Diameter	Pitch 90 – 4 TPI Up to 4 in	$(3.5 + 4.6L) \mu\text{in}$	Thread Measuring Wires
Thread Rings (Adjustable) Pitch Diameter Tactile Fit (Set to Plug)	Up to 4 in	See footnote <sup>5</sup>	Comparison to Thread Setting Plug
Optical Comparators <sup>1,2</sup> Linear Accuracy	Up to 6 in 6 to 12 in	$(43 + 11L) \mu\text{in}$ $(30 + 7.5L) \mu\text{in}$	Comparison to Glass Scale
Magnification	5X to 100X	350 $\mu\text{in}$	Glass Scale (Sphere)
Surface Plates <sup>1,2</sup> Overall Flatness	Up to 238 inDL	$(25 + 2.9L) \mu\text{in}$	Comparison to Laser System
Local Area Flatness	Up to 238 inDL	34 $\mu\text{in}$	Repeat-O-Meter
CMMs <sup>1,2</sup> (Linearity only)	(0 to 144) in	$(25 + 2.4L) \mu\text{in}$	Comparison to Laser Measuring System
VMMs <sup>1,2</sup> (Linearity)	Up to 6 in	$(32 + 4.1L) \mu\text{in}$	Comparison to Glass Scales
Horizontal Measuring Systems <sup>1,2</sup>	Up to 8 in (8 to 60) in	$(6 + 1.7L) \mu\text{in}$ $(3 + 2.5L) \mu\text{in}$	Comparison to Gage Blocks
Feeler/Thickness Gages <sup>2</sup>	Up to 0.2 in	$(4.3 + 3L) \mu\text{in}$	Comparison to Horizontal Measuring System
Indicator Calibrator <sup>2,7</sup> Linearity	Up to 6 in	60 $\mu\text{in}$	Comparison to Horizontal Measuring System
Groove Micrometers <sup>2,7</sup>	Up to 12 in	$(44 + 2.6L) \mu\text{in}$	Comparison to Gage Blocks
Stereo Microscopes <sup>1</sup> Reticle Linearity	Up to 2 in	870 $\mu\text{in}$	Comparison to Stage Micrometer
Toolmakers Microscope <sup>2,7</sup> Scale Linearity	Up to 4 in	$(774 + 70L) \mu\text{in}$	Comparison to Stage Micrometer
Length Standards <sup>2</sup>	(1 to 60) in	$(3.4 + 3.5L) \mu\text{in}$	Comparison to Horizontal Measuring System



## Length – Dimensional Metrology

Eau Claire, WI

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Inside Micrometers <sup>2</sup>	Up to 8 in (8 to 60) in	$(6 + 1.7L) \mu\text{in}$ $(3 + 2.5L) \mu\text{in}$	Comparison to Horizontal Measuring System
Parallels <sup>2</sup> Steel Granite	Up to 18 in Up to 18 in	$(96.3 + 1.8L) \mu\text{in}$ $(48.6 + 0.7L) \mu\text{in}$	Comparison to Electronic Amplifier with Probe, Surface Plate
Thickness Gages <sup>2</sup> Dial Digital	Up to 1 in	$410 \mu\text{in} + 0.6R$ $44 \mu\text{in} + 0.6R$	Comparison to Gage Blocks
Thread Micrometers <sup>2</sup> (Screw Thread, Pitch Point) Linearity <sup>7</sup> Anvil Wear	Up to 12 in Up to 12 in	$(44 + 2.6L) \mu\text{in}$ $690 \mu\text{in}$	Comparison to Gage Blocks, Thread Setting Plug

## Mass and Mass Related

Eau Claire, WI

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Force <sup>1</sup> (Source)	(0.035 to 16) ozf (1 to 10) lbf (10 to 50) lbf (50 to 500) lbf	0.018 % of reading 0.018 % of reading 0.018 % of reading 0.036 % of reading	Comparison to Dead Weight
Pressure <sup>1</sup> (Absolute)	(0 to 100) psia	0.07 psi	Comparison to Pressure Calibrator
Pressure <sup>1</sup> (Gauge)	(0 to 1) inH <sub>2</sub> O (-15 to 30) psig (0.036 to 1) psig (100 to 300) psig (300 to 1 000) psig (1 000 to 10 000) psig	0.003 5 inH <sub>2</sub> O 0.019 psi 0.013 psi 0.12 psi 0.4 psi 2.4 psi	Comparison to Pressure Calibrator
Torque Tools <sup>1</sup>	(5 to 50) lbf·in (50 to 400) lbf·in (400 to 1000) lbf·in (80 to 250) lbf·ft (250 to 600) lbf·ft (600 to 2 000) lbf·ft	0.33 % of reading 0.36 % of reading 0.4 % of reading 0.28 % of reading 0.51 % of reading 0.75 % of reading	Comparison to Torque Tester

## Mass and Mass Related

Eau Claire, WI

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Torque Transducers <sup>1</sup>	0.5 ozf-in to 1 000 lbf-ft	0.08 % of reading	Comparison to Dead Weights, Torque Arms
Scales and Balances <sup>1,6</sup>	(0 to 500) mg 500 mg to 5 g (5 to 10) g (10 to 30) g (30 to 50) g (50 to 100) g (100 to 200) g (200 to 300) g 300 g to 1 kg (1 to 2) kg (2 to 3) kg (3 to 5) kg (5 to 10) kg (10 to 20) kg (20 to 25) kg (25 to 30) kg	10 µg 34 µg 50 µg 74 µg 0.12 mg 0.25 mg 0.5 mg 0.75 mg 2.5 mg 5 mg 7.5 mg 12 mg 25 mg 50 mg 62 mg 75 mg	Comparison to ASTM E617 Class 1 Weights, and internal calibration procedure utilized in the calibration of the weighing system.
Scales and Balances <sup>1,6</sup>	(0.5 to 1 000) lb	0.01 % of reading	Comparison to ASTM E617 Class 6 Weights, and internal calibration procedure utilized in the calibration of the weighing system.

## Thermodynamic

Eau Claire, WI

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Temperature – Measure <sup>1</sup>	(-20 to 100) °C (100 to 425) °C (425 to 500) °C	0.058 °C 0.069 °C 0.086 °C	Comparison to Digital Temperature Gage
Humidity – Measure <sup>1</sup>	(10 to 90) %RH (90 to 98) %RH	1.1 %RH 2 %RH	Comparison to Humidity Indicator

## Thermodynamic

Eau Claire, WI

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Temperature Uniformity Survey <sup>1</sup> (TUS)	Up to 200 °F (200 to 1 000) °F (1 000 to 1 400) °F (1 400 to 1 800) °F (1 800 to 2 000) °F (2 000 to 2 300) °F	1.6 °F 1.8 °F 2.1 °F 2.9 °F 4.1 °F 4.3 °F	Comparison to Temperature Datalogger, Type K Thermocouples per AMS 2750.

## Time and Frequency

Eau Claire, WI

Parameter/Equipment	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method, and/or Equipment
Frequency – Reference <sup>4</sup>	1 MHz	25 µHz	Comparison to Fluke 5522A Multi Product Calibrator

## DIMENSIONAL MEASUREMENT

### 2 Dimensional

Eau Claire, WI

Specific Tests and / or Properties Measured	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method and/or Equipment
2-D Non-contact <sup>2</sup>	(15.4 x 10.8) in	(126 + 12L) µin	Comparison to Vision System

### 3 Dimensional

Eau Claire, WI

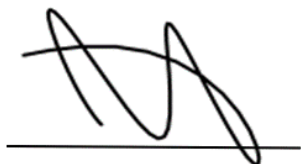
Specific Tests and / or Properties Measured	Range	Expanded Uncertainty of Measurement (+/-)	Reference Standard, Method and/or Equipment
Dimensional Inspection Contact <sup>2</sup>	(16 x 18 x 14) in	(209+ 1.2L) µin	Comparison to Coordinate Measuring Machine

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Calibration and Measurement Capability (CMC) is expressed in terms of the measurement parameter, measurement range, expanded uncertainty of measurement and reference standard, method, and/or equipment. The expanded uncertainty of measurement is expressed as the standard uncertainty of the measurement multiplied by a coverage factor of 2 ( $k=2$ ), corresponding to a confidence level of approximately 95%.

Notes:

1. On-site calibration service is available for this parameter, since on-site conditions are typically more variable than those in the laboratory, larger measurement uncertainties are expected on-site than what is reported on the accredited scope
2. The use of (R) signifies the Resolution of the unit under test; the use of (L) represents Length in inches; the use of (D) represents Diameter in inches; " = arc-second.
3. Uncertainties listed for Electromagnetic - DC/Low Frequency and RF/Microwave does not include possible contributions from a "best available" unit under test
4. Derivatives of 10 MHz will have different uncertainties due to resolution, noise, and gating errors.
5. The tactile fit of an adjustable thread ring to a thread-setting plug is not a measurement of pitch diameter. The uncertainty for this pitch diameter setting is based on the contributors associated with the thread setting plug and environmental contributors only.
6. The CMC for scales and balances are highly dependent upon the resolution of the unit under test. The uncertainties presented here does not include the resolution of the unit under test. The resolution will be included in the reported measurement uncertainty at the time of calibration.
7.  $0.6R$  will be added to the Measurement Uncertainty at the time of calibration, where  $R$  is the resolution of the device under calibration.



Jason Stine, Vice President

